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**(54) Method and apparatus for packaging a chip**

Verfahren und Vorrichtung zum Verpacken von Chips

Procédé et appareil d'emballage de puces

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**WO-A-93/09668**                      **US-A- 5 300 779**  
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**Description****BACKGROUND OF THE INVENTION**

[0001] The present inventions relate to the fabrication and placement of materials at known locations on a substrate. In particular, one embodiment of the invention provides a method and associated apparatus for packaging a substrate having diverse sequences at known locations on its surface.

[0002] Techniques for forming sequences on a substrate are known. For example, the sequences may be formed according to the pioneering techniques disclosed in United States Patent Number 5,143,854 (Pirrung et al.), PCT WO 92/10092, or United States patent number 5,571,639. WO93/09668 discloses a device having a series of channels, grooves or spots on or adjacent to a substrate on which high-density arrays of diverse polymer sequences are synthesized.

[0003] The prepared substrates will have a wide range of applications. For example, the substrates may be used for understanding the structure-activity relationship between different materials or determining the sequence of an unknown material. The sequence of such unknown material may be determined by, for example, a process known as sequencing by hybridization. In one method of sequencing by hybridization, a sequences of diverse materials are formed at known locations on the surface of a substrate. A solution containing one or more targets to be sequenced is applied to the surface of the substrate. The targets will bind or hybridize with only complementary sequences on the substrate.

[0004] The locations at which hybridization occurs can be detected with appropriate detection systems by labelling the targets with a fluorescent dye, radioactive isotope, enzyme, or other marker. Exemplary systems are described in United States Patent Number 5,143,854 (Pirrung et al.). Information regarding target sequences can be extracted from the data obtained by such detection systems.

[0005] By combining various available technologies, such as photolithography and fabrication techniques, substantial progress has been made in the fabrication and placement of diverse materials on a substrate. For example, thousands of different sequences may be fabricated on a single substrate of about 1.28 cm<sup>2</sup> in only a small fraction of the time required by conventional methods. Such improvements make these substrates practical for use in various applications, such as biomedical research, clinical diagnostics, and other industrial markets, as well as the emerging field of genomics, which focuses on determining the relationship between genetic sequences and human physiology.

[0006] As commercialization of such substrates becomes widespread, an economically feasible and high-throughput device and method for packaging the substrates are desired.

**SUMMARY OF THE INVENTION**

[0007] Methods and devices for packaging a substrate having an array of probes fabricated on its surface are disclosed. In some embodiments, a body containing a cavity is provided. A substrate having an array of probes is attached to the cavity using, for example, an adhesive. The body includes inlets that allow fluids into and through the cavity. A seal is provided for each inlet to retain the fluid within the cavity. An opening is formed below the cavity to receive a temperature controller for controlling the temperature in the cavity. By forming a sealed thermostatically controlled chamber in which fluids can easily be introduced, a practical medium for sequencing by hybridization is provided.

[0008] In other embodiments, the body is formed by acoustically welding two pieces together. The concept of assembling the body from two pieces is advantageous. For example, the various features of the package (i.e., the channels, sealing means, and orientation means) are formed without requiring complex machining or designing. Thus, the packages are produced at a relatively low cost.

[0009] In connection with one aspect of the invention, a method for making the chip package is disclosed. In particular, the method comprises the steps of first forming a plurality of probe arrays on a substrate and separating the substrate into a plurality of chips. Typically, each chip contains at least one probe array. A chip is then mated to a package having a reaction chamber with fluid inlets. When mated, the probe array is in fluid communication with the reaction chamber.

[0010] A further understanding of the nature and advantages of the inventions herein may be realized by reference to the remaining portions of the specification and the attached drawings.

**BRIEF DESCRIPTION OF THE DRAWINGS**

[0011]

FIG. 1a illustrates a wafer fabricated with a plurality of probe arrays.

FIG. 1b illustrates a chip.

FIG. 2a illustrates a scribe and break device.

FIG. 2b illustrates the wafer mounted on a pick and place frame.

FIGS. 2c-2d illustrate the wafer, as displayed by the scribe and break device during alignment.

FIG. 3 illustrates a chip packaging device.

FIG. 4 illustrates the chip packaging device assembled from two components.

FIGS. 5a-5b illustrate the top and bottom view of a top casing of the chip packaging device.

FIG. 5c illustrates a different cavity orientation.

FIG. 6 illustrates a cross sectional view of the packaging device.

FIG. 7 illustrates the bottom view of a bottom casing

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of the chip packaging device.

FIGS. 8a-8b illustrate an acoustic welding system.

FIGS. 9a-9c illustrate the acoustic welding process used in assembling the chip packaging device.

FIG. 10 illustrates an adhesive dispensing system used in attaching the chip to the chip packaging device.

FIGS. 11-13 illustrate in greater detail the adhesive dispensing system of FIG. 10.

FIGS. 14a-14d illustrate the procedure for aligning the system of FIG. 10.

FIGS. 15a-15e illustrate images obtained during the alignment process of FIGS. 14a-14d.

FIGS. 16a-16b illustrate an alternative embodiment of a packaging device.

FIGS. 17a-17b illustrate another embodiment of a packaging device.

FIG. 18 illustrates an alternative embodiment for attaching the chip to the packaging device.

FIG. 19 illustrates another embodiment for attaching the chip to the packaging device.

FIGS. 20a-20b illustrate yet another embodiment for attaching the chip to the packaging device.

FIG. 21 illustrates an alternative embodiment for attaching the chip to the packaging device.

FIG. 22 illustrates another embodiment for attaching the chip to the packaging device.

FIG. 23 illustrates an alternative embodiment for sealing the cavity on the packaging device.

FIG. 24 illustrates another alternative embodiment for sealing the cavity on the packaging device.

FIG. 25 illustrates yet another embodiment for sealing the cavity on the packaging device.

FIGS. 26a-26b illustrate an alternative embodiment for sealing the cavity on the packaging device.

FIGS. 27a-27b illustrate an alternative embodiment for mounting the chip.

FIG. 28 illustrates an agitation system.

FIG. 29 illustrates an alternative embodiment of the agitation system.

FIG. 30 illustrates another embodiment of the agitation system.

## DESCRIPTION OF THE PREFERRED EMBODIMENT CONTENTS

### [0012]

#### I. Definitions

#### II. General

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#### c. Fluid Retention

#### d. Chip Orientation

#### e. Parallel Diagnostics

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#### I. Definitions

[0013] The following terms are intended to have the following general meanings as they are used herein:

1. **Probe:** A probe is a surface-immobilized molecule that is recognized by a particular target and is sometimes referred to as a ligand. Examples of probes that can be investigated by this invention include, but are not restricted to, agonists and antagonists for cell membrane receptors, toxins and venoms, viral epitopes, hormones (e.g., opioid peptides, steroids, etc.), hormone receptors, peptides, enzymes, enzyme substrates, cofactors, drugs, lectins, sugars, oligonucleotides or nucleic acids, oligosaccharides, proteins, and monoclonal antibodies.

2. **Target:** A target is a molecule that has an affinity for a given probe and is sometimes referred to as a receptor. Targets may be naturally-occurring or manmade molecules. Also, they can be employed in their unaltered state or as aggregates with other species. Targets may be attached, covalently or noncovalently, to a binding member, either directly or via a specific binding substance. Examples of targets which can be employed by this invention include, but are not restricted to, antibodies, cell membrane receptors, monoclonal antibodies and antisera reactive with specific antigenic determinants (such as on viruses, cells or other materials), drugs, oligonucleotides or nucleic acids, peptides, cofactors, lectins, sugars, polysaccharides, cells, cellular membranes, and organelles. Targets are sometimes referred to in the art as anti-probes or anti-ligands. As the term "targets" is used herein, no difference in meaning is intended. A "Probe Target Pair" is formed when two macromolecules have combined through molecular recognition to form a complex.

#### II. General

[0014] The present invention provides economical and efficient packaging devices for a substrate having an array of probes fabricated thereon. The probe arrays may be fabricated according to the pioneering techniques disclosed in United States Patent Number 5,143,854 (Pirrung et al.), PCT WO 92/10092.

[0015] According to one aspect of the techniques de-

scribed therein, a plurality of probe arrays are immobilized at known locations on a large substrate or wafer.

[0016] Fig. 1a illustrates a wafer 100 on which numerous probe arrays 110 are fabricated. The wafer 100 may be composed of a wide range of material, either biological, nonbiological, organic, inorganic, or a combination of any of these, existing as particles, strands, precipitates, gels, sheets, tubing, spheres, containers, capillaries, pads, slices, films, plates, slides, etc. The wafer may have any convenient shape, such as a disc, square, sphere, circle, etc. The wafer is preferably flat but may take on a variety of alternative surface configurations. For example, the wafer may contain raised or depressed regions on which a sample is located. The wafer and its surface preferably form a rigid support on which the sample can be formed. The wafer and its surface are also chosen to provide appropriate light-absorbing characteristics. For instance, the wafer may be a polymerized Langmuir Blodgett film, functionalized glass, Si, Ge, GaAs, GaP, SiO<sub>2</sub>, SiN<sub>4</sub>, modified silicon, or any one of a wide variety of gels or polymers such as (poly) tetrafluoroethylene, (poly)vinylidenedifluoride, polystyrene, polycarbonate, or combinations thereof. Other materials with which the wafer can be composed of will be readily apparent to those skilled in the art upon review of this disclosure. In a preferred embodiment, the wafer is flat glass or single-crystal silicon.

[0017] Surfaces on the solid wafer will usually, though not always, be composed of the same material as the wafer. Thus, the surface may be composed of any of a wide variety of materials, for example, polymers, plastics, resins, polysaccharides, silica or silica-based materials, carbon, metals, inorganic glasses, membranes, or any of the above-listed wafer materials.

[0018] Wafer 100 includes a plurality of marks 145 that are located in streets 150 (area adjacent to the probe arrays). Such marks may be used for aligning the masks during the probe fabrication process. In effect, the marks identify the location at which each array 110 is to be fabricated. The probe arrays may be formed in any geometric shape. In some embodiments, the shape of the array may be squared to minimize wasted wafer area. After the probe arrays have been fabricated, the wafer is separated into smaller units known as chips. The wafer, for example, may be about 5 x inches on which 16 probe arrays, each occupying an area of about 12.8 cm<sup>2</sup>, are fabricated.

[0019] Fig. 1b illustrates a chip that has been separated from the wafer. As illustrated, chip 120 contains a probe array 110 and a plurality of alignment marks 145. The marks serve multiple functions, such as: 1) aligning the masks for fabricating the probe arrays, 2) aligning the scribe for separating the wafer into chips, and 3) aligning the chip to the package during the attachment process. In some embodiments, such chips may be of the type known as Very Large Scale Immobilized Polymer Synthesis (VLSIPS™) chips.

[0020] According to a specific embodiment, the chip

contains an array of genetic probes, such as an array of diverse RNA or DNA probes. In some embodiments, the probe array will be designed to detect or study a genetic tendency, characteristic, or disease. For example, the probe array may be designed to detect or identify genetic diseases such as cystic fibrosis or certain cancers (such as P53 gene relevant to some cancers).

[0021] According to one embodiment, the wafer is separated into a plurality of chips using a technique known as scribe and break. Fig. 2a illustrates a fully programmable computer controlled scribe and break device, which in some embodiments is a DX-III Scribe breaker manufactured by Dynatex International™. As shown, the device 200 includes a base 205 with a rotation stage 220 on which a wafer is mounted. The rotation stage includes a vacuum chuck for fixing the wafer thereon. A stepper motor, which is controlled by the system, rotates stage 220. Located above the stage is a head unit 230 that includes a camera 232 and cutter 231. Head unit 230 is mounted on a dual-axis frame. The camera generates an image of the wafer on video display 210. The video display 210 includes a cross hair alignment mark 215. The camera, which includes a zoom lens and a fiber optic light, allows a user to inspect the wafer on the video display 210. A control panel 240 is located on the base for operating device 200.

[0022] In operation, a user places a wafer 100 on a frame 210 as illustrated in Fig. 2b. The surface of frame 210 is composed of a flexible and sticky material. The tackiness of the frame prevents the chips from being dispersed and damaged during the breaking process. Frame 210 may be a pick and place frame or a hoop that is commonly associated with fabrication of semiconductors. Referring back to Fig. 2a, a user places the frame with the wafer on the rotation stage 220. In some embodiments, the frame is held on the rotation stage by vacuum pressure. The user then aligns the wafer by examining the image displayed on the video display 210.

[0023] According to one embodiment, wafer alignment is achieved in two steps. First, using the control panel 240, the user rotates stage 220. The stage is rotated until streets 150 are aligned with the cross hair 215 on the display, as illustrated in Fig. 2c. Next, the user moves the cutter until it is aligned at the center of one of the streets. This step is performed by aligning horizontal line 216 of the cross hair between alignment marks 145, as shown in Fig. 2d.

[0024] Once the cutter is aligned, the user instructs the device to scribe the wafer. In some embodiments, various options are available to the user, such as scribe angle, scribe pressure, and scribe depth. These parameters will vary depending on the composition and/or thickness of the wafer. Preferably, the parameters are set to scribe and break the wafer without causing any damage thereto or penetrating through the frame. The device repeatedly scribes the wafer until all the streets in one axis have been scribed, which in one embodiment is repeated 5 times (a 4x4 matrix of probe arrays). The

user then rotates the stage 90° to scribe the perpendicular streets.

[0025] Once the wafer has been scribed, the user instructs the device to break or separate the wafer into chips. Referring back to Fig. 2a, the device 200 breaks the wafer by striking it beneath the scribe with an impulse bar located under the rotation table 220. The shock from the impulse bar fractures the wafer along the scribe. Since most of the force is dissipated along the scribe, device 200 is able to produce high breaking forces without exerting significant forces on the wafer. Thus, the chips are separated without causing any damage to the wafer. Once separated, the chips are then packaged. Of course, other more conventional techniques, such as the sawing technique disclosed in U.S. Patent Number 4,016,855, incorporated herein by reference for all purposes, may be employed.

#### IV. Details of One Embodiment of the Invention

##### a. Chip Package

[0026] Fig. 3 illustrates a device for packaging the chips. Package 300 contains a cavity 310 on which a chip is mounted. The package includes inlets 350 and 360 which communicate with cavity 310. Fluids are circulated through the cavity via inlets 350 and 360. A septum, plug, or other seal may be employed to seal the fluids in the cavity. Alignment holes 330 and 335 may be provided for alignment purposes. In some embodiments, the package may include a non-flush edge 320. In some detection systems, the packages may be inserted into a holder similar to an audio cassette tape. The asymmetrical design of the package will assure correct package orientation when inserted into the holder.

[0027] Fig. 4 illustrates one embodiment of the package. As shown in Fig. 4, the chip package is manufactured by mating two substantially complementary casings 410 and 420 to form finished assembly 300. Preferably, casings 410 and 420 are made from injection molded plastic. Injection molding enables the casings to be formed inexpensively. Also, assembling the package from two parts simplifies the construction of various features, such as the internal channels for introducing fluids into the cavity. As a result, the packages may be manufactured at a relatively low cost.

[0028] Figs. 5a-5b show the top casing 410 in greater detail. Fig. 5a shows a top view and Fig. 5b shows a bottom view. Referring to Fig. 5a, top casing 410 includes an external planar surface 501 having a cavity 310 therein. In some embodiments, the surface area of casing 410 sufficiently accommodates the cavity. Preferably, the top casing is of sufficient size to accommodate identification labels or bar codes in addition to the cavity. In a specific embodiment, the top casing is about 1.5" wide, 2" long, and 0.2" high.

[0029] Cavity 310 is usually, though not always, located substantially at the center of surface 501. The cavity

may have any conceivable size, shape, or orientation. Preferably, the cavity is slightly smaller than the surface area of the chip to be placed thereon and has a volume sufficient to perform hybridization. In one embodiment, the cavity may be about 0.58" wide, 0.58" long, and 0.2" deep.

[0030] Cavity 310 may include inlets 350 and 360. Selected fluids are introduced into and out of the cavity via the inlets. In some embodiments, the inlets are located at opposite ends of the cavity. This configuration improves fluid circulation and regulation of bubble formation in the cavity. The bubbles agitate the fluid, increasing the hybridization rate between the targets and complementary probe sequences. In one embodiment, the inlets are located at the top and bottom end of the cavity when the package is oriented vertically such as at the opposite corners of the cavity. Locating the inlet at the highest and lowest positions in the cavity facilitates the removal of bubbles from the cavity.

[0031] Fig. 5c illustrates an alternative embodiment in which cavity 310 is oriented such that the edges of the cavity 310 and the casing 410 are non-parallel. This configuration allows inlets 350 and 360 to be situated at the absolute highest and lowest locations in the cavity when the package is vertically oriented. As a result, bubbles or fluid droplets are prevented from being potentially trapped in the cavity.

[0032] Referring back to Fig. 5a, a depression 550 surrounds the cavity. In some embodiments, a ridge 560 may be provided at the edge of the depression so as to form a trough. The ridge serves to support the chip above the cavity. To attach the chip to the package, an adhesive may be deposited in the trough. This configuration promotes efficient use of chip surface area, thus increasing the number of chips yielded from a wafer.

[0033] Top casing 410 includes alignment holes 330 and 335. In some embodiments, holes 330 and 335 are different in size to ensure correct orientation of the package when mounted on an alignment table. Alternatively, the holes may have different shapes to achieve this objective. Optionally, the holes taper radially inward from surface 501 toward 502 to reduce the friction against alignment pins while still maintaining adequate contact to prevent slippage.

[0034] Referring to Fig. 5b, channels 551 and 561 are optionally formed on internal surface 502. Channels 551 and 561 communicate with inlets 350 and 360 respectively. A depression 590 is formed below cavity. According to some embodiments, the shape of depression 590 is symmetrical to the cavity with exception to corners 595 and 596, which accommodate the inlets. The depth of depression 590 may be, for example, about 0.7". As a result, the bottom wall of the cavity is about 0.05" thick. Depression 590 may receive a temperature controller to monitor and maintain the cavity at the desired temperature. By separating the temperature controller and cavity with a minimum amount of material, the temperature within the cavity may be controlled more efficiently and

accurately. Alternatively, channels may be formed on surface 502 for circulating air or water to control the temperature within the cavity.

[0035] In some embodiments, certain portions 595 of internal surface 502 may be eliminated or cored without interfering with the structural integrity of the package when assembled. Coring the casing reduces the wall thickness, causing less heat to be retained during the injection molding process; potential shrinkage or warpage of the casing is significantly reduced. Also, coring decreases the time required to cool the casing during the manufacturing process. Thus, manufacturing efficiency is improved.

[0036] In one embodiment, the top casing and bottom casing are mated together using a technique known as acoustic or ultrasonic welding. Accordingly, "energy directors" 510 are provided. Energy directors are raised ridges or points, preferably v-shaped, that are used in an acoustic welding process. The energy directors are strategically located, for example, to seal the channels without interfering with other features of the package and to provide an adequate bond between the two casings. Alternatively, the casings may be mated together by screws, glue, clips, or other mating techniques.

[0037] Figs. 6 shows a cross sectional view of the cavity 310 with chip 120 mounted thereon in detail. As shown, a depression 550 is formed around cavity 310. The depression includes a ridge 560 which supports chip 120. The ridge and the depression create a trough around cavity 310. In some embodiments, the trough is sufficiently large to receive an adhesive 630 for attaching the chip to the package. In one embodiment, the trough is about 0.08" wide and 0.06" deep. When mounted, the edge of the chip protrudes slightly beyond ridge 550, but without contacting side 625 of the depression. This configuration permits the adhesive to be dispensed onto the trough and provides adequate surface area for the adhesive to attach chip 120 to the package.

[0038] According to some embodiments, the back surface 130 of chip 120 is at least flush or below the plane formed by surface 501 of casing 410. As a result, chip 120 is shielded by surface 501 from potential damage. This configuration also allows the packages to be easily stored with minimal storage area since the surfaces are substantially flat.

[0039] Optionally, the bottom of the cavity includes a light absorptive material, such as a glass filter or carbon dye, to prevent impinging light from being scattered or reflected during imaging by detection systems. This feature improves the signal-to-noise ratio of such systems by significantly reducing the potential imaging of undesired reflected light.

[0040] Fig. 7 shows the internal surface of bottom casing 420 in greater detail. As shown, the bottom casing 420 is substantially planar and contains an opening 760 therein. Preferably, the casing 420 is slightly wider or slightly longer than the top casing. In one embodiment, casing 420 is about 1.6" wide, 2.0" long, and 0.1" deep,

which creates a non-flush edge on the finish assembly. As previously mentioned, this design ensures that the package is correctly oriented when mounted onto the detection systems.

[0041] In some embodiments, opening 760 is spatially located at about the depression below the cavity. The opening also has substantially the same geometric configuration as the depression to allow the temperature controller to contact as much of the bottom of the cavity as possible.

[0042] Internal surface 701 of casing 420 includes depressions 730 and 740. A port 731 is located in depression 730 and a port 741 is located in depression 740. Ports 731 and 741 communicate with channels on the top casing (350 and 360 in Fig. 5b) when the package is assembled. A seal 790, which may be a septum composed of rubber, teflon/rubber laminate, or other sealing material is provided for each depression. The septum may be of the type commonly used to seal and reseal vessels when a needle is inserted into the septum for addition/removal of fluids. The septums, when seated in the depressions, extend slightly above surface, which in some embodiments is about 0.01".

[0043] This design causes casings 410 and 420 to exert pressure on the septum, forming a seal between the ports and the channels. The seal is maintained even after fluid is injected into the cavity since the pressure immediately forces the septum to reseal itself after the needle or other fluid injecting means is removed from the port. Thus, an efficient and economical seal for retaining fluid in the cavity is provided.

[0044] Also, casing 420 includes the complementary half alignment holes 330 and 335, each tapering radially inward from the external surface. Further, certain areas 765 on internal surface 701 may be cored, as similar to the internal surface of the top casing.

#### b. Assembly of Chip Package

[0045] According to one embodiment, the top and bottom casing are attached by a technique known as ultrasonic or acoustic welding. Fig. 8a is a schematic diagram of acoustic welding system used for assembling the package. In some embodiments, the welding system 800 is a HS Dialog ultrasonic welder manufactured by Hermann Ultrasonics Inc. System 800 includes a platform 850 mounted on base 810. Platform 850 accommodates the top and bottom casings during the assembling process.

[0046] An acoustic horn 860 is mounted on a frame above platform 850. The horn translates vertically (toward and away from platform 850) on the frame by air pressure. The horn is connected to a frequency generator 870, which in some embodiments is a 20 KHz generator manufactured by Hermann Ultrasonics Inc. System 800 is controlled by a controller 880, which, for example, may be a Dialog 2012 manufactured by Hermann Ultrasonics Inc. Controller 880 may be config-

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ured to accept commands from a digital computer system 890. Computer 890 may be any appropriately programmed digital computer of the type that is well known to those skilled in the art such as a Gateway 486DX operating at 33 MHz.

[0047] Fig. 8b illustrates platform 850 in greater detail. The platform 850 is substantially planar and includes alignment pins 851 and 852. Alignment pins 851 and 852 are used to align both the top and bottom casings during the welding process. In some embodiments, a pad 890, which may be composed of silicone rubber or other energy absorbing material, is located on platform 850 to prevent damage to the package during assembly.

[0048] Fig. 9a illustrates the acoustic welding system in operation. As shown, bottom casing 420, having a septum 790 seated in each depression, is mounted onto platform table 850 and held in place by alignment pins. Top casing 410 is then aligned above the bottom casing with alignment pins. The system then commences the welding process by lowering horn 860 until it contacts the top surface of casing 410.

[0049] Fig. 9b illustrates the casing and horn in detail. As shown, the horn 860 presses against top casing 410, thereby forcing energy directors 510 to interface with bottom casing 420. The system then activates the frequency generator, causing the welding horn to vibrate.

[0050] Fig. 9c illustrates in detail the energy directors during the welding process. As shown in step 9001, welding horn 860 forces energy directors 510 against bottom casing 420. At step 9002, the system vibrates the welding horn, which in some embodiments is at 20 KHz. The energy generated by the horn melts the energy directors. Simultaneously, the horn translates downward against the package. At step 9003, the pressure exerted by the horn causes the energy directors to fuse with the bottom casing. At step 9004, the welding process is completed when the horn reaches its weld depth, for example, of about 0.01". Of course, the various welding parameters may be varied, according to the composition of the materials used, to achieve optimum results.

#### c. Chip Attachment

[0051] According to some embodiments, an ultraviolet cured adhesive attaches the chip to the package. Fig. 10 schematically illustrates an adhesive dispensing system used in attaching the chip. The dispensing system 1000 includes an attachment table 1040 to accommodate the package during the attachment process. A chip alignment table 1050 for aligning the chip is located adjacent to attachment table 1040. A head unit 1030 for dispensing the adhesive is located above tables 1040 and 1050. The head unit 1030 also includes a camera that generates an output to video display 1070. Video display 1070, in some embodiments, includes a cross hair alignment mark 1071. The head unit is mounted on a dual-axis (x-y) frame for positioning during alignment and attachment of the chip. The operation of the dis-

pensing system is controlled by a computer 1060, which in some embodiments may be Gateway 486DX operating at 33 MHz.

[0052] Fig. 11 illustrates the attachment table in greater detail. The attachment table 1040 has a substantially flat platform 1110 supported by a plurality of legs 1105. Alignment pins 1115 and 1116, which secure the package during the attachment process, are located on the surface of platform 1110.

[0053] Optionally, a needle 1120 is provided. Needle 1120 includes a channel 1121 and is connected to a vacuum pump. In operation, the needle is inserted into one of the ports of the package in order to generate a vacuum in the cavity. The vacuum pressure secures the chip to the package during the attachment process.

[0054] Fig. 12a shows table 1050 in greater detail. Table 1050 includes a substantially flat platform 1210 having a depression 1240 for holding a chip. In some embodiments, a port 1241 is provided in depression 1240. Port 1241 is connected to a vacuum pump which creates a vacuum in the depression for immobilizing the chip therein. Platform 1210 is mounted on a combination linear rotary stage 1246, which in some embodiments may be a model 26LR manufactured by DARDAL, and a single axis translation stage 1245, which may be a model CR2226HSE2 manufactured by DARDAL.

[0055] Fig. 12b illustrates depression 1240 in greater detail. As shown, a ledge 1241 surrounds the depression 1240. Ledge 1241 supports the chip when it is placed above depression 1240. Since the chips are placed over the depression with the probes facing the table, this design protects the probes from being potentially damaged during alignment.

[0056] Fig. 13 illustrates the head unit 1030 in greater detail. As shown, the head unit 1030 includes a camera assembly 1320 that generates an output to a video display. A light 1360 is provided to enable the camera to focus and image an object of interest. The head unit also includes an ultraviolet light 1350 for curing the adhesive, a vacuum pickup 1330 for moving chip during the attachment process, and an adhesive dispenser 1340.

[0057] In operation, a chip package is placed onto table 1040. As previously described, the alignment pins on the table immobilize the package. The user begins the chip attachment process by calibrating the head unit. This may be done by moving the camera above the package and aligning it with a mark on the package, as shown in Fig. 14a. For convenience, one of the alignment pins may be used as an alignment mark. Fig. 14b illustrates a typical image 1440 generated by the camera during this step. As shown, the head unit is not aligned with pin 1480. To align the head unit, the user translates it in both the x and y direction until pin 1480 is located at the intersection 1477 of the cross hair on the video display, as illustrated in Fig. 14c.

[0058] Next, the chip is inserted into the depression on the chip alignment table. Fig. 14c is a flow chart indicating the steps for aligning the chip. At step 1410, the

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system positions the camera (head unit) above one of the chip's alignment marks. The camera images the alignment mark on the video display. At this point, the mark is normally misaligned (i.e., the mark is not located at the intersection of the cross hair alignment mark). At step 1420, the user adjusts the chip alignment table in both the x and y direction until the mark is substantially located at the intersection of the cross hair. Since no rotational adjustments were made, the mark may be misaligned angularly.

[0059] At step 1430, the user instructs the system to move the camera above a second alignment mark, which usually is at an opposite corner of the chip. Again, an image of the alignment mark is displayed. At this stage, the alignment mark is probably misaligned in the x, y, and angular directions. At step 1440, the user adjusts the rotational stage, x-stage, and y-stage, if necessary, to align the mark with the cross hair on the video display. In instances where the rotational stage has been rotated, the first alignment mark will become slightly misaligned. To compensate for this shift, the user repeats the alignment process beginning at step 1450 until both marks are aligned. Of course, image processing techniques may be applied for automated head unit and chip alignment.

[0060] Fig. 15a is an example of an image displayed by the video screen during step 1410. As shown, the first alignment mark (lower left corner of the chip) is not aligned with the cross hair marking. Fig. 15b exemplifies an image of the first alignment mark after adjustments were made by the user. Fig. 15c illustrates a typical image displayed by video screen during step 1430. As illustrated, the second alignment mark (upper right corner of the chip) is misaligned in the x, y, and angular directions. Fig. 15d illustrates an image of the second mark following initial adjustments by the user at step 1440. Fig. 15e illustrates the orientation of the second alignment mark after the chip has been aligned.

[0061] Once the chip is aligned, the vacuum holding the chip on the attachment table is released. Thereafter, the pickup on the head unit removes the chip from the table and aligns it on the cavity of the package. In some embodiments, the chip is mated to the pickup by a vacuum.

[0062] Optionally, the user may check to ensure that the chip is correctly aligned on the cavity by examining the chip's alignment marks with the camera. If the chip is out of position, the chip is removed and realigned on the alignment table. If the chip is correctly positioned, the system deposits an adhesive by moving the dispenser along the trough surrounding the cavity. In some embodiments, the vacuum is released before depositing the adhesive in the trough. This step is merely precautionary and implemented to ensure that the vacuum does not cause any adhesive to seep into the cavity. Once the adhesive is deposited, the system reexamines the chip to determine if the adhesive had moved the chip out of position. If the chip is still aligned, the head unit

locates the ultraviolet light above the adhesive and cures it for a time sufficient to harden the adhesive, which in one embodiment is about 10 seconds. Otherwise, the chip is realigned.

[0063] Upon completion, the chip package will have a variety of uses. For example, the chip package will be useful in sequencing genetic material by hybridization. In sequencing by hybridization, the chip package is mounted on a hybridization station where it is connected to a fluid delivery system. Such system is connected to the package by inserting needles into the ports and puncturing the septums therein. In this manner, various fluids are introduced into the cavity for contacting the probes during the hybridization process.

[0064] Usually, hybridization is performed by first exposing the sample with a prehybridization solution. Next, the sample is incubated under binding conditions with a solution containing targets for a suitable binding period. Binding conditions will vary depending on the application and are selected in accordance with the general binding methods known including those referred to in: Maniatis et al., Molecular Cloning: A Laboratory Manual (1989), 2nd Ed., Cold Spring Harbor, N.Y. and Berger and Kimmel, Methods in Enzymology, Volume 152, Guide to Molecular Cloning Techniques (1987), Academic Press, Inc., San Diego, CA.; Young and Davis (1983) Proc. Natl. Acad. Sci. (U.S.A.) 80: 1194.

[0065] In some embodiments, the solution may contain about 1 molar of salt and about 1 to 50 nanomolar of targets. Optionally, the fluid delivery system includes an agitator to improve mixing in the cavity, which shortens the incubation period. Finally, the sample is washed with a buffer, which may be 6X SSPE buffer, to remove the unbound targets. In some embodiments, the cavity is filled with the buffer after washing the sample.

[0066] Thereafter, the package may be aligned on a detection or imaging system, such as those disclosed in United States Patent Number 5,143,854 (Pirrung et al.) or United States Patent Number 5,627,487.

[0067] Such detection systems may take advantage of the package's asymmetry (i.e., non-flush edge) by employing a holder to match the shape of the package specifically. Thus, the package is assured of being properly oriented and aligned for scanning. The imaging systems are capable of qualitatively analyzing the reaction between the probes and targets. Based on this analysis, sequence information of the targets is extracted.

### III. Details on Alternative Embodiments

#### a. Chip Package Orientation

[0068] Figs. 16a-16b illustrate an alternative embodiment of the package. Fig. 16a shows a top view and Fig. 16b shows a bottom view. As shown in Fig. 16a, a cavity 1620 is located on a top surface 1610 of the package body 1600. The body includes alignment holes 1621 and 1622 that are used, for example, in mating the



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chip to the package. Optionally, a plurality of ridges 1690 is located at end 1660 of the body. The friction created by ridges 1690 allows the package to be handled easily without slippage.

[0069] The body also includes two substantially parallel edges 1630 and 1640. As shown, edge 1640 is narrowed at end 1665 to create an uneven edge 1645. The asymmetrical design of the body facilitates correct orientation when mounted onto detection systems. For example, detection systems may contain a holder, similar to that of an audio cassette tape, in which end 1665 is inserted.

[0070] Referring to Fig. 16b, ports 1670 and 1671 communicate with cavity 1620. A seal is provided for each port to retain fluids in the cavity. Similar to the top surface, the bottom surface may optionally include a plurality of ridges 1690 at end 1660.

[0071] Figs. 17a-17b illustrate an alternative embodiment of the package. Fig. 17a shows a top view and Fig. 17b shows a bottom view. Referring to Fig. 17a, a cavity 1720 is located on a top surface 1710 of the package body 1700. The body may be formed in the shape of a disk with two substantially parallel edges 1730 and 1740. Alignment holes 1721 and 1722, which may be different in size or shape, are located on the body. In some embodiments, the package is inserted like an audio cassette tape into detection systems in a direction parallel to edges 1730 and 1740. Edges 1730 and 1740 and alignment holes prevent the package from being inserted incorrectly into the detection systems.

[0072] As shown in Fig. 17b, ports 1730 and 1740 are located on the bottom surface 1715 of the package. Ports 1730 and 1740 communicate with cavity 1720 and each include a seal 1780 for sealing fluids in the cavity.

#### b. Chip Attachment

[0073] Fig. 18 illustrates an alternative embodiment for attaching the chip to the package. As shown, two concentric ledges 1810 and 1820 surround the perimeter of cavity 310. Ledge 1820 supports the chip 120 when mounted above cavity 310. Ledge 1810, which extends beyond chip 120, receives an adhesive 1860 such as ultraviolet cured silicone, cement, or other adhesive for attaching the chip thereto.

[0074] Fig. 19 illustrates another embodiment for attaching the chip to the package. According to this embodiment, a ledge 1910 is formed around cavity 310. Preferably, the ledge is sufficiently large to accommodate an adhesive 1920 such as an adhesive film, adhesive layer, tape, or any other adhesive layer. Chip 120 attaches to the package when it contacts the adhesive film.

[0075] Fig. 20a illustrates yet another embodiment for attaching a chip to the package. As shown, a clamp 2010, such as a frame having a plurality of fingers 2015, attaches the chip to the package. Fig. 20b illustrates a cross sectional view. A ridge 2020 on surface 501 sur-

rounds cavity 310. The ridge includes a ledge 2025 upon which chip 120 rests. Optionally, a gasket or a seal 2070 is located between the ledge and chip to ensure a tight seal around cavity 310. Clamp 2010 is attached to side 2040 of ridge 2020 and surface 501. In some embodiments, clamp 2010 is acoustically welded to the body. Accordingly, clamp 2010 includes energy directors 2050 located at its bottom. Alternatively, screws, clips, adhesives, or other attachment techniques may be used to mate clamp 2010 to the package. When mated, fingers 2015 secure chip 120 to the package.

[0076] Fig. 21 illustrates an alternative embodiment for attaching the chip to the package. A ridge 2110, having a notch 2115 at or near the top of ridge 2110, encompasses the cavity 310. chip 120 is wedged and held into position by notch 2115. Thereafter, a process known as heat staking is used to mount the chip. Heat staking includes applying heat and force at side 2111 of ridge, thus forcing ridge tightly against or around chip 120.

[0077] Fig. 22 shows another embodiment of attaching a chip onto a package. As shown, a channel 2250 surrounds cavity 310. A notch 2240 for receiving the chip 120 is formed along or near the top of the cavity 310. In some embodiments, a gasket or seal 2270 is placed at the bottom of the notch to ensure a tight seal when the chip is attached. Once the chip is located at the notch, a V-shaped wedge 2260 is inserted into channel 2250. The wedge forces the body to press against chip's edges and seal 2260, thus mating the chip to the package. This process is known as compression sealing. Other techniques such as insert molding, wave soldering, surface diffusion, laser welding, shrink wrap, o-ring seal, surface etching, or heat staking from the top may also be employed.

#### c. Fluid Retention

[0078] Fig. 23 shows an alternative embodiment of package that employs check valves to seal the inlets. As shown, depressions 2305 and 2315 communicate with cavity 310 through inlets 350 and 360. Check valves 2310 and 2320, which in some embodiments may be duck-billed check valves, are seated in depressions 2305 and 2315. To introduce a fluid into the cavity, a needle is inserted into the check valve. When the needle is removed, the check valve reseals itself to prevent leakage of the fluid.

[0079] Fig. 24 illustrates another package that uses reusable tape for sealing the cavity 310. As shown, a tape 2400 is located above inlets 350 and 360. Preferably, end 2430 of tape is permanently fixed to surface 2480 while end 2410 remains unattached. The mid section 2420 of the tape is comprised of non-permanent adhesive. This design allows inlets to be conveniently sealed or unsealed without completely separating the tape from the package.

[0080] Fig. 25 illustrates yet another embodiment of the package that uses plugs to retain fluids within the

cavity. As shown, depressions 2520 and 2530 communicate with cavity 310 via inlets 350 and 360. A plug 2510, which in some embodiment may be composed of rubber or other sealing material, is mated to each of the depressions. Plugs 2510 are easily inserted or removed for sealing and unsealing the cavity during the hybridization process.

[0081] Fig. 26a illustrates a package utilizing sliding seals for retaining fluids within the cavity. The seals are positioned in slots 2610 that are located above the inlets. The slots act as runners for guiding the seals to and from the inlets. Fig. 26b illustrates the seal in greater detail. Seal 2640, which may be composed of rubber, teflon rubber, or other sealing material, is mated to each slot 2610. The seal includes a handle 2650 which extends through the slot. Optionally, the bottom of the seal includes an annular protrusion 2645 to ensure mating with inlet 350. The inlet is sealed or unsealed by positioning the seal appropriately along the slot. Alternatively, spring loaded balls, rotary ball valves, plug valves, or other fluid retention techniques may be employed.

#### d. Chip Orientation

[0082] Figs. 27a-27b illustrate an alternative embodiment of the package. Fig. 27a illustrates a top view and Fig. 27b shows a cross sectional view. As shown, package 2700 includes a cavity 2710 on a surface 2705. A chip 2790 having an array of probes 2795 on surface 2791 is mated to the bottom of cavity 2710 with an adhesive 2741. The adhesive, for example, may be silicone, adhesive tape, or other adhesive. Alternatively, clips or other mounting techniques may be employed. Optionally, the bottom of the cavity may include a depression in which a chip is seated.

[0083] This configuration provides several advantages such as: 1) permitting the use of any type of substrate (i.e., non-transparent or non-translucent), 2) yielding more chips per wafer since the chip does not require an edge for mounting, and 3) allowing chips of various sizes or multiple chips to be mated to the package.

[0084] A cover 2770 is mated to the package for sealing the cavity. Preferably, cover 2770 is composed of a transparent or translucent material such as glass, acrylic, or other material that is penetrable by light. Cover 2770 may be mated to surface 2705 with an adhesive 2772, which in some embodiments may be silicone, adhesive film, or other adhesive. Optionally, a depression may be formed around the cavity such that surface 2271 of the cover is at least flush with surface 2705. Alternatively, the cover may be mated to surface 2705 according to any of the chip attachment techniques described herein.

[0085] Inlets 2750 and 2751 are provided and communicate with cavity 2710. Selected fluids are circulated through the cavity via inlets 2750 and 2751. To seal the fluids in the cavity, a septum, plug, or other seal may be employed. In alternative embodiments, any of the fluid

retention techniques described herein may be utilized.

#### e. Parallel Hybridization and Diagnostics

5 [0086] In an alternative embodiment, the body is configured with a plurality of cavities. The cavities, for example, may be in a 96-well micro-titre format. In some embodiments, a chip is mounted individually to each cavity according to the methods described above. Alternatively, the probe arrays may be formed on the wafer in a format matching that of the cavities. Accordingly, separating the wafer is not necessary before attaching the probe arrays to the package. This format provides significant increased throughput by enabling parallel testing of a plurality of samples.

#### V. Details of an Agitation System

10 [0087] Fig. 28 illustrates an agitation system in detail. As shown, the agitation system 2800 includes two liquid containers 2810 and 2820, which in the some embodiments are about 10 milliliters each. Container 2810 communicates with port 350 via tube 2850 and container 2820 communicates with port 360 via tube 2860. An inlet port 2812 and a vent port 2811 are located at or near the top of container 2810. Container 2820 also includes an inlet port 2822 and a vent 2821 at or near its top. Port 2812 of container 2810 and port 2822 of container 2820 are both connected to a valve assembly 2828 via valves 2840 and 2841. An agitator 2801, which may be a nitrogen gas ( $N_2$ ) or other gas, is connected to valve assembly 2828 by fitting 2851. Valves 2840 and 2841 regulate the flow of  $N_2$  into their respective containers. In some embodiments, additional containers (not shown) may be provided, similar to container 2810, for introducing a buffer and/or other fluid into the cavity.

15 [0088] In operation, a fluid is placed into container 2810. The fluid, for example, may contain targets that are to be hybridized with probes on the chip. Container 2810 is sealed by closing port 2811 while container 2820 is vented by opening port 2821. Next,  $N_2$  is injected into container 2810, forcing the fluid through tube 2850, cavity 310, and finally into container 2820. The bubbles formed by the  $N_2$  agitate the fluid as it circulates through the system. When the amount of fluid in container 2810 nears empty, the system reverses the flow of the fluid by closing valve 2840 and port 2821 and opening valve 2841 and port 2811. This cycle is repeated until the reaction between the probes and targets is completed.

20 [0089] In some applications, foaming may occur when  $N_2$  interacts with the fluid. Foaming potentially inhibits the flow of the fluid through the system. To alleviate this problem, a detergent such as CTAB may be added to the fluid. In one embodiment, the amount of CTAB added is about 1 millimolar. Additionally, the CTAB affects the probes and targets positively by increasing the rate at which they bind, thus decreasing the reaction time required.

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[0090] The system described in Fig. 28 may be operated in an alternative manner. According to this technique, back pressure formed in the second container is used to reverse the flow of the solution. In operation, the fluid is placed in container 2810 and both ports 2811 and 2821 are closed. As  $N_2$  is injected into container 2810, the fluid is forced through tube 2850, cavity 310, and finally into container 2820. Because the vent port in container 2820 is closed, the pressure therein begins to build as the volume of fluid and  $N_2$  increases. When the amount of fluid in container 2810 nears empty, the flow of  $N_2$  into container 2810 is terminated by closing valve 2840. Next, the circulatory system is vented by opening port 2811 of container 2810. As a result, the pressure in container 2820 forces the solution back through the system toward container 2810. In one embodiment, the system is injected with  $N_2$  for about 3 seconds and vented for about 3 seconds. This cycle is repeated until hybridization between the probes and targets is completed.

[0091] Fig. 29 illustrates an alternative embodiment of the agitation system. System 2900 includes a vortexer 2910 on which the chip package 300 is mounted. A container 2930 for holding the fluid communicates with inlet 350 via tube 2950. A valve 2935 may be provided to control the flow of solution into the cavity. In some embodiments, circulator 2901, which may be a  $N_2$  source or other gas source, is connected to container 2930. Alternatively, a pump or other fluid transfer device may be employed. The flow of  $N_2$  into container 2930 is regulated by a valve 2936. Circulator 2901 is also connected to inlet tube 2950 via a valve 2902.

[0092] A waste container 2920 communicates with port 360 via outlet tube 2955. In one embodiment, a liquid sensor 2940 may be provided for sensing the presence of liquid in outlet tube 2955. Access to the waste container may be controlled by a valve 2921. Optionally, additional containers (not shown), similar to container 2930, may be employed for introducing a buffer or other fluid into the cavity.

[0093] The system is initialized by closing all valves and filling container 2930 with, for example, a fluid containing targets. Next, valves 2936, 2935, and 2955 are opened. This allows  $N_2$  to enter container 2930 which forces the fluid to flow through tube 2950 and into the cavity. When the cavity is filled, valves 2935, 2936, and 2955 are closed to seal the fluid in the cavity. Next, the vortexer is activated to vibrate the chip package, similar to a paint mixer. In some embodiments, the vortexer may vibrate the package at about 3000 cycles per minutes. The motion mixes the targets in the fluid, shortening the incubation period. In some embodiments, the vortexer rotates the chip package until hybridization is completed. Upon completion, valve 2902 and 2955 are opened to allow  $N_2$  into the cavity. The  $N_2$  empties the fluid into waste container 2920. Subsequently, the cavity may be filled with a buffer or other fluid.

[0094] Fig. 30 illustrates an alternative embodiment in which the agitation system is partially integrated into

the chip package. As shown, chip package 300 includes a cavity 310 on which the chip is mounted. Cavity 310 is provided with inlets 360 and 350. The package also includes chambers 3010 and 3020. A port 3021 is provided in chamber 3010 and is connected to inlet 360 by a channel 3025.

[0095] Chamber 3010 is equipped with ports 3011 and 3012. Port 3012 communicates with inlet 350 through a channel 3015. Channel 3015 is provided with a waste port 3016 that communicates with a fluid disposal system 3500 via a tube 3501. A valve 3502 regulates the flow of fluids into the disposal system. In some embodiments, the disposal system includes a waste container 3510 and fluid recovery container 3520 which are connected to tube 3501. A valve 3530 is provided to direct the flow of fluids into either the waste container or recovery container.

[0096] Port 3011 is coupled to a fluid delivery system 3600 through a tube 3601. Fluids flowing into chamber 3010 from the fluid delivery system are regulated by a valve 3602. The fluid delivery system includes fluid containers 3610 and 3620 that are interconnected with a tube 3690. Container 3610, which may hold a fluid containing targets, includes ports 3616 and 3615. Port 3616 is connected to tube 3690. A valve 3612 controls the flow of the fluid out of container 3610. A circulator 3605, which may be a  $N_2$  source, is connected to port 3615 of container 3610. Alternatively, any type of gas, pump or other fluid transfer device may be employed. The flow of  $N_2$  into container 3610 is controlled by a valve 3618. A valve 3619 may also be provided to vent container 3610.

[0097] Container 3620, which may hold a buffer, is provided with ports 3625 and 3626. Circulator 3605 is connected to port 3625. A valve 3621 is provided to control the flow of  $N_2$  into container 3620. Port 3626 is connected to tube 3690 via a valve 3622. Valve 3622 regulates the flow of the buffer out of container 3620. Optionally, additional containers (not shown), similar to container 3620, may be configured for introducing other fluids into the cavity. A valve 3690 connects circulator 3605 to tube 3690 for controlling the flow of  $N_2$  directly into the package. A valve 3652 is provided for venting the fluid delivery system.

[0098] In the initial operating state, all valves are shut. To start the hybridization process, a fluid containing targets is introduced into chamber 301 by opening valves 3602, 3612 and 3618. This injects  $N_2$  into container 3610 which forces the fluid to flow through 3601 and into chamber 3010. When chamber 3010 is filled, valves 3612 and 3618 are closed. Next, valve 3642 is opened, allowing  $N_2$  to flow directly into chamber 3010. The  $N_2$  agitates and circulates the fluid into cavity 310 and out to chamber 3020. As the volume of fluid and  $N_2$  in chamber 3020 increase, likewise does the pressure therein. When chamber 3020 approaches its capacity, valve 3642 is closed to stop the fluid flow. Thereafter, the system is vented by opening valve 3652. Venting the sys-

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tem allows the back pressure in chamber 3020 to reverse the flow of fluids back into chamber 3010. When chamber 3010 is filled, valve 3652 is closed and valve 3642 is opened to reverse the fluid flow. This cycle is repeated until hybridization is completed.

[0099] When hybridization is completed, the system may be drained. This procedure depends on which chamber the fluid is located in. If the fluid is located in chamber 3020, then valve 3502 is opened, while valve 3530 is positioned to direct the fluid into the appropriate container (recovery or waste). The pressure in chamber 3020 forces the fluid through port 3016, tube 3501, and into the disposal system. If the fluid is in chamber 3010, then valve 3502 and 3642 are opened. As a result, N<sub>2</sub> forces the fluid in chamber 3010 through port 3501 and into the disposal system.

[0100] Once the system is emptied, all valves are closed. A buffer or other fluid may be introduced into the cavity. For example, the cavity may be filled with a buffer by opening valves 3601, 3621, and 3622. This injects N<sub>2</sub> into container 3620 which forces the buffer therein to flow through the system until it fills cavity 310. In the alternative, ultrasonic radiation, heat, magnetic beads, or other agitation techniques may be employed.

[0101] The present inventions provide commercially feasible devices for packaging a probe chip. It is to be understood that the above description is intended to be illustrative and not restrictive. Many embodiments will be apparent to those skilled in the art upon reviewing the above description. Merely as an example, the package may be molded or machined from a single piece of material instead of two. Also, other asymmetrical designs may be employed to orient the package onto the detection systems.

## Claims

1. A method of making probe chips comprising the steps of:

forming a plurality of probe arrays on a substrate (100);  
separating said substrate into a plurality of chips (120), each of said chips comprising at least one probe array (110) thereon; and  
mating at least one of said chips to a package, said package comprising a reaction chamber (310, 1720, 2710), said reaction chamber comprising inlets (350, 360, 1730, 1740, 2750, 2751) for flowing fluid therein, said at least one probe array in fluid communication with said reaction chamber.

2. The method as recited in claim 1 wherein said package is made by the steps of:

injection molding first and second halves of said

package; and  
mating said first and second halves together.

3. The method as recited in claim 2 wherein said halves are injection molded plastic.

4. The method as recited in claim 3 wherein one of said halves comprises flow channels (551, 561) therein, said flow channels in communication with said inlets (350, 360).

5. The method as recited in claim 4 further comprising the step of applying a reenterable seal (790, 2310, 2520, 2530, 2640) to flow channels in said package.

6. The method as recited in claim 1 wherein said substrate (100) comprises alignment marks (145) for forming said probe arrays (110) thereon in a desired position, and wherein said alignment marks (145) are used to identify locations for said separating of said substrate into chips (120).

7. The method as recited in claim 1 wherein said substrate comprises alignment marks for forming said probe arrays thereon in a desired position, and wherein said step of mating said chips to said package uses said alignment marks for positioning said chips at a desired location on said package.

8. The method as recited in claim 1 wherein said package comprises an alignment structure thereon, wherein said step of mating said chip to said package uses said alignment structures to position said package at a desired position.

9. The method as recited in claim 1 wherein said package comprises an alignment structure thereon, and further comprising the step of identifying the location of at least one target on said probe array in a scanner, wherein said package is placed at a desired location in said scanner using said alignment structure.

10. The method as recited in claim 9 wherein said alignment structure is a plurality of holes in said package.

11. The method as recited in claim 1 wherein said step of forming a plurality of probe arrays comprises the steps of:

selectively exposing said substrate to light;  
coupling selected monomers to said substrate where said substrate has been exposed to light;

12. The method as recited in claim 1 wherein said step of separating comprises the steps of:

scribing said substrate in desired locations;

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- breaking said substrate along said scribe lines.
13. The method as recited in claim 1 wherein said step of forming a plurality of probe arrays on said substrate is a step of forming a plurality of oligonucleotide probe arrays on said substrate. 5
14. The method as recited in claim 13 further comprising the steps of flowing labeled oligonucleotide target molecules through said reaction chamber and identifying where said target molecules have bound to said substrate. 10
15. The method as recited in claim 14 wherein said package comprises a temperature probe and further comprising the step of monitoring and adjusting a temperature in said reaction chamber. 15
16. The method as recited in claim 1 wherein said package is formed by the steps of: 20
- forming first and second package portions; and
  - acoustically welding said first and second package portions together.
17. The method as recited in claim 1 wherein said step of mating said chips to packages comprises the step of binding said chips to said package with an adhesive. 25
18. The method as recited in claim 17, wherein said packages comprise a recessed region (550) thereon, whereby said chips (120) do not extend above a surface of said packages. 30
19. The method as recited in claim 1 further comprising the step of flowing target molecules through said reaction chamber. 35
20. The method as recited in claim 19 wherein said step of flowing is a step of flowing material from an inlet along a first diagonal of a generally rectangular reaction chamber to an outlet along said diagonal of said generally rectangular reaction chamber. 40
21. The method as recited in claim 19 wherein said step of flowing target molecules through said reaction chamber comprises the steps of piercing an inlet septum and flowing said target molecules in a fluid through said reaction chamber. 45
22. An apparatus for packaging a substrate, said apparatus comprising: 50
- a substrate having a first surface (110) and a second surface (120), said first surface comprising a probe array;
  - a body having a mounting surface with a fluid cavity, said second surface attached to said cavity; and
  - a cover attached to said mounting surface for sealing said cavity;
- wherein said cavity comprises an inlet port and an outlet port, said inlet and outlet ports permitting fluids to circulate into and through said cavity.
23. The apparatus of claim 22 wherein said inlet and outlet ports comprise a reenterable seal.
24. The apparatus of claim 22 wherein said probe array comprises an array of oligonucleotide probes.
25. The apparatus of claim 22 wherein said body comprises a depression for receiving a temperature controller for controlling and maintaining the reaction temperature in said cavity.
26. The apparatus of claim 22 wherein said body comprises a first half mated to a second half.
27. The apparatus of claim 26 wherein said first and second halves are injection molded plastic.
28. The apparatus of claim 27 wherein one of said halves comprises a cavity, said cavity having an inlet port and an outlet port.
29. The apparatus of claim 28 wherein one of said halves comprises flow channels, said flow channels in communication with said inlet and outlet ports when said first and second halves are mated together.
30. The apparatus of claim 29 wherein said flow channels comprise a reenterable seal for sealing fluid in said cavity.
31. The apparatus of claim 22 wherein said body further comprises an alignment structure, said alignment structure used for maintaining said body in a desired position when mounted on detection system.
32. The apparatus of claim 31 wherein said alignment structure comprises a plurality of holes.
33. The apparatus of claim 31 wherein said alignment structure comprises a non-flush edge.
34. The apparatus of claim 22 wherein the substrate is a polymerized Langmuir Blodgett film, functionalized glass, Si, Ge, GaAs, GaP, SiO<sub>2</sub>, SiN<sub>4</sub>, modified silicon, (poly)tetrafluoroethylene, (poly)vinylidene difluoride, polystyrene, polycarbonate or combinations thereof. 55

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35. The apparatus of claim 22, wherein the substrate is the cover sealing the cavity.

36. The apparatus of claim 22, wherein the apparatus is asymmetrically designed to assure correct package orientation when inserted into a holder.

37. The apparatus of claim 22, wherein the cavity is slightly smaller than the surface area of the chip to be placed thereon and has a volume sufficient to perform hybridization.

38. A method of evaluating probe chips comprising the steps of:

forming a plurality of probe arrays on a substrate;  
separating said substrate into a plurality of chips, each of said chips comprising at least one probe array thereon;  
mating at least one of said chips to a package, said package comprising a reaction chamber, said reaction chamber in fluid communication with an inlet and outlet, said at least one probe array in fluid communication with said reaction chamber; and  
flowing labeled target molecules into said reaction chamber, said labeled target molecules reacting with said at least one probe array.

39. The method as recited in claim 38 wherein said step of forming a plurality of probe arrays is a step of forming a plurality of oligonucleotide probe arrays.

40. The method as recited in claim 38 wherein said inlet and said outlet comprise reenterable seals, and said step of flowing labeled target molecules into said reaction chamber comprises the steps of:

piercing said seal of said inlet;  
piercing said seal of said outlet; and  
flowing said labeled target molecules from

said inlet into said cavity and out through said outlet.

41. The method as recited in claim 38 further comprising the step of agitating said target molecules to facilitate reaction between said at least one probe array and said labeled target molecules.

42. The method as recited in claim 41 further comprising the step of identifying at least one location where said labeled target molecules are located on said at least one probe array.

43. The method as recited in claim 42 where said identifying step comprises the step of placing said package in a scanner, said scanner being capable of im-

aging said labeled target molecules on said at least one probe array.

44. The method as recited in claim 43 wherein said package comprises an alignment structure such that said package is placed in a desired position in said scanner.

45. The method as recited in claim 44 wherein said alignment structure comprises a non-flush edge.

46. The method as recited in claim 44 wherein said alignment structure comprises a plurality of alignment holes.

#### Patentansprüche

1. Verfahren zur Herstellung von Sonden-Chips, Schritte umfassend, bei denen man:

eine Mehrzahl von Sonden-Arrays auf einem Substrat (100) bildet;  
das Substrat in eine Mehrzahl von Chips (120) teilt, wobei jeder der Chips mindestens ein Sonden-Array (110) darauf umfasst; und  
mindestens einen der Chips mit einem Gehäuse zusammenfügt, wobei das Gehäuse eine Reaktionskammer (310, 1720, 2710) umfasst, wobei die Reaktionskammer Zulaufe (350, 360, 1730, 1740, 2750, 2751) zum Fließen von Fluid darin umfasst, und wobei das mindestens eine Sonden-Array in Fluidverbindung mit der Reaktionskammer steht.

2. Verfahren nach Anspruch 1, wobei das Gehäuse durch Schritte hergestellt wird, bei denen man:

die ersten und zweiten Hälften des Gehäuses mittels Spritzguss herstellt; und  
die ersten und zweiten Hälften zusammenfügt.

3. Verfahren nach Anspruch 2, wobei die Hälften aus Spritzgusskunststoff bestehen.

4. Verfahren nach Anspruch 3, wobei eine der Hälften Fließkanäle (551, 561) darin umfasst, wobei die Fließkanäle in Verbindung mit den Zulaufen (350, 360) stehen.

5. Verfahren nach Anspruch 4, das ferner einen Schritt umfasst, bei dem Fließkanäle in das Gehäuse mit einer wiedereintrittsfesten Dichtung (790, 2310, 2520, 2530, 240) versehen werden.

6. Verfahren nach Anspruch 1, wobei das Substrat (100) Ausrichtungsmarkierungen (145) umfasst, um die Sonden-Arrays (110) darauf in gewünschter

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Position zu bilden, und die Ausrichtungsmarkierungen (145) dazu verwendet werden, Orte für die Trennung des Substrates in Chips (120) zu identifizieren.

7. Verfahren nach Anspruch 1, wobei das Substrat Ausrichtungsmarkierungen umfasst, um die Sonden-Arrays darauf in gewünschter Position zu bilden, und wobei der Schritt des Zusammenfügens der Chips mit dem Gehäuse die Ausrichtungsmarkierungen dazu verwendet, die Chips an einem gewünschten Ort an dem Gehäuse zu positionieren.

8. Verfahren nach Anspruch 1, wobei das Gehäuse eine Ausrichtungsstruktur darauf umfasst, wobei der Schritt des Zusammenfügens des Chips mit dem Gehäuse die Ausrichtungsstrukturen dazu verwendet, das Gehäuse in einer gewünschten Position zu positionieren.

9. Verfahren nach Anspruch 1, wobei das Gehäuse eine Ausrichtungsstruktur darauf umfasst, und das Verfahren ferner den Schritt der Identifizierung des Ortes mindestens eines Ziels auf dem Sonden-Array in einem Scanner umfasst, wobei das Gehäuse an einem gewünschten Ort in dem Scanner unter Verwendung der Ausrichtungsstruktur platziert wird.

10. Verfahren nach Anspruch 9, wobei die Ausrichtungsstruktur eine Mehrzahl von Löchern in dem Gehäuse ist.

11. Verfahren nach Anspruch 1, wobei der Schritt der Bildung einer Mehrzahl von Sonden-Arrays Schritte umfasst, bei denen man:

das Substrat selektiv Licht aussetzt;  
ausgewählte Monomere an das Substrat koppelt, wo das Substrat Licht ausgesetzt wurde.

12. Verfahren nach Anspruch 1, wobei der Schritt des Teilens Schritte umfasst, bei denen man:

das Substrat an gewünschten Orten einritzet;  
das Substrat längs der eingeritzten Linien bricht.

13. Verfahren nach Anspruch 1, wobei der Schritt der Bildung einer Mehrzahl von Sonden-Arrays auf dem Substrat ein Schritt ist, bei dem man eine Mehrzahl von Oligonukleotid-Sonden-Arrays auf dem Substrat bildet.

14. Verfahren nach Anspruch 13, das ferner Schritte umfasst, bei denen man markierte Oligonukleotid-Ziel-Moleküle durch die Reaktionskammer fließen lässt und identifiziert, wo die Ziel-Moleküle an das

Substrat gebunden haben.

15. Verfahren nach Anspruch 14, wobei das Gehäuse einen Temperatur-Sensor umfasst und ferner einen Schritt umfasst, bei dem man in der Reaktionskammer eine Temperatur überwacht und einstellt.

16. Verfahren nach Anspruch 1, wobei das Gehäuse durch Schritte gebildet wird, bei denen man:

erste und zweite Anteile des Gehäuses herstellt; und  
die ersten und zweiten Gehäuseanteile akustisch zusammenschweißt.

17. Verfahren nach Anspruch 1, wobei der Schritt des Zusammenfügens der Chips mit Gehäusen einen Schritt umfasst, bei dem man die Chips mit einem Klebemittel mit dem Gehäuse verbindet.

18. Verfahren nach Anspruch 17, wobei die Gehäuse eine vertiefte Region (550) darauf umfassen, wobei die Chips (120) nicht über eine Oberfläche der Gehäuse herausragen.

19. Verfahren nach Anspruch 1, das ferner einen Schritt umfasst, bei dem man Ziel-Moleküle durch die Reaktionskammer fließen lässt.

20. Verfahren nach Anspruch 19, wobei der Schritt des fließen Lassens ein Schritt ist, bei dem man Material von einem Zulauf entlang einer ersten Diagonalen einer im wesentlichen rechtwinkligen Reaktionskammer zu einem Ablauf entlang der Diagonalen der im wesentlichen rechtwinkligen Reaktionskammer fließen lässt.

21. Verfahren nach Anspruch 19, wobei der Schritt des fließen Lassens von Ziel-Molekülen durch die Reaktionskammer Schritte umfasst, bei denen man ein Zulaufseptum durchsticht und die Ziel-Moleküle in einem Fluid durch die Reaktionskammer fließen lässt.

22. Vorrichtung zur Verpackung eines Substrates, wobei die Vorrichtung umfasst:

ein Substrat mit einer ersten Oberfläche (110) und einer zweiten Oberfläche (120), wobei die erste Oberfläche ein Sonden-Array umfasst;  
einen Körper mit einer Auflage-Oberfläche mit einem Fluid-Hohlraum, wobei die zweite Oberfläche mit dem Hohlraum verbunden ist; und  
eine Abdeckung, die mit der Auflage-Oberfläche verbunden ist, um den Hohlraum abzudichten;

wobei der Hohlraum eine Zulauföffnung und eine

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Ablauföffnung umfasst, wobei die Zulauf- und Ablauföffnungen es Fluiden erlauben, in und durch den Hohlraum zu zirkulieren.

23. Vorrichtung nach Anspruch 22, wobei die Zulauf- und Ablauföffnungen eine wiedereintrittsfeste Dichtung umfassen. 5
24. Vorrichtung nach Anspruch 22, wobei das Sonden-Array ein Array von Oligonukleotid-Sonden umfasst. 10
25. Vorrichtung nach Anspruch 22, wobei der Körper eine Ausnehmung umfasst, um einen Temperaturregler zur Steuerung und Beibehaltung der Reaktionstemperatur im Hohlraum zu erhalten. 15
26. Vorrichtung nach Anspruch 22, wobei der Körper eine erste Hälfte umfasst, die an eine zweite Hälfte angefügt ist. 20
27. Vorrichtung nach Anspruch 26, wobei die ersten und zweiten Hälften aus Spritzkunststoff bestehen.
28. Vorrichtung nach Anspruch 27, wobei eine der Hälften einen Hohlraum umfasst, wobei der Hohlraum eine Zulauföffnung und eine Ablauföffnung hat. 25
29. Vorrichtung nach Anspruch 28, wobei eine der Hälften Fließkanäle umfasst, wobei die Fließkanäle in Verbindung mit den Zulauf- und Ablauföffnungen stehen, wenn die ersten und zweiten Hälften zusammengefügt sind. 30
30. Vorrichtung nach Anspruch 29, wobei die Fließkanäle eine wiedereintrittsfeste Dichtung zur Abdichtung von Fluid in dem Hohlraum umfassen. 35
31. Vorrichtung nach Anspruch 22, wobei der Körper ferner eine Ausrichtungsstruktur umfasst, wobei die Ausrichtungsstruktur dazu verwendet wird, den Körper bei Anbringung auf einem Detektionssystem in einer gewünschten Position zu halten. 40
32. Vorrichtung nach Anspruch 31, wobei die Ausrichtungsstruktur eine Mehrzahl von Löchern umfasst. 45
33. Vorrichtung nach Anspruch 31, wobei die Ausrichtungsstruktur eine nicht-bündige Kante umfasst. 50
34. Vorrichtung nach Anspruch 22, wobei das Substrat ein polymerisierter Langmuir-Blodgett-Film, funktionalisiertes Glas, Si, Ge GaAs, GaP, SiO<sub>2</sub>, SiN<sub>4</sub>, modifiziertes Silizium, (Poly)tetrafluorethylen, (Poly)vinylidendifluorid, Polystyren, Polycarbonat oder Kombinationen derselben ist. 55
35. Vorrichtung nach Anspruch 22, wobei das Substrat

die Abdeckung ist, die den Hohlraum abdichtet.

36. Vorrichtung nach Anspruch 22, wobei die Vorrichtung asymmetrisch konstruiert ist, um die korrekte Orientierung des Gehäuses bei Einfügen in einen Halter zu gewährleisten.
37. Vorrichtung nach Anspruch 22, wobei der Hohlraum geringfügig kleiner ist als die Oberflächen des Chips, der darauf platziert werden soll, und ein Volumen aufweist, das ausreicht, um eine Hybridisierung durchzuführen.
38. Verfahren zur Evaluierung von Sonden-Chips, Schritte umfassend, bei denen man:
  - eine Mehrzahl von Sonden-Arrays auf einem Substrat bildet;
  - das Substrat in eine Mehrzahl von Chips teilt, wobei jeder der Chips mindestens ein Sonden-Array darauf umfasst;
  - mindestens einen der Chips mit einem Gehäuse zusammenfügt, wobei das Gehäuse eine Reaktionskammer umfasst, wobei die Reaktionskammer in Fluidverbindung mit einem Zulauf und einem Ablauf steht, wobei das mindestens eine Sonden-Array in Fluidverbindung mit der Reaktionskammer steht; und
  - markierte Ziel-Moleküle in die Reaktionskammer fließen lässt, wobei die markierten Ziel-Moleküle mit dem mindestens einen Sonden-Array reagieren.
39. Verfahren nach Anspruch 38, wobei der Schritt der Bildung einer Mehrzahl von Sonden-Arrays ein Schritt ist, bei dem man eine Mehrzahl von Oligonukleotid-Sonden-Arrays bildet.
40. Verfahren nach Anspruch 38, wobei der Zulauf und der Ablauf wiedereintrittsfeste Dichtungen umfassen, und der Schritt des fließens Lassens von markierten Ziel-Molekülen in die Reaktionskammer Schritte umfasst, bei denen man:
  - die Dichtung des Zulaufs durchsticht;
  - die Dichtung des Ablaufs durchsticht; und
  - die markierten Ziel-Moleküle vom Zulauf in den Hohlraum und durch den Ablauf hinaus fließen lässt.
41. Verfahren nach Anspruch 38, das ferner einen Schritt umfasst, bei dem man die Ziel-Moleküle schüttelt, um eine Reaktion zwischen dem mindestens einen Sonden-Array und den markierten Ziel-Molekülen zu erleichtern.
42. Verfahren nach Anspruch 41, das ferner einen Schritt umfasst, bei dem man mindestens einen Ort



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identifiziert, an dem die markierten Ziel-Moleküle auf dem mindestens einen Sonden-Array lokalisiert sind.

43. Verfahren nach Anspruch 42, wobei der Schritt der Identifizierung einen Schritt umfasst, bei dem man das Gehäuse in einen Scanner platziert, wobei der Scanner in der Lage ist, die markierten Ziel-Moleküle auf dem mindestens einen Sonden-Array abzubilden.

44. Verfahren nach Anspruch 43, wobei das Gehäuse eine Ausrichtungsstruktur umfasst, so dass das Gehäuse in einer gewünschten Position in dem Scanner platziert wird.

45. Verfahren nach Anspruch 44, wobei die Ausrichtungsstruktur eine nicht-bündige Kante umfasst.

46. Verfahren nach Anspruch 44, wobei die Ausrichtungsstruktur eine Mehrzahl von Ausrichtungsblöcken umfasst.

#### Revendications

1. Procédé de fabrication de puces à sondes comprenant les étapes de :

formation d'une pluralité de groupements de sondes sur un substrat (100) ;  
séparation dudit substrat en une pluralité de puces (120), chacune desdites puces comprenant au moins un groupement de sondes (110) sur celles-ci ; et  
appariement d'au moins une desdites puces à un boîtier, ledit boîtier comprenant une chambre de réaction (310, 1720, 2710), ladite chambre de réaction comprenant des entrées (350, 360, 1730, 1740, 2750, 2751) pour passer un fluide dans celles-ci, ledit au moins un groupement de sondes en communication de fluide avec ladite chambre de réaction.

2. Procédé selon la revendication 1, dans lequel ledit boîtier est réalisé par les étapes de :

moulage par injection des première et seconde moitiés dudit boîtier ; et  
appariement desdites première et seconde moitiés ensemble.

3. Procédé selon la revendication 2, dans lequel lesdites moitiés sont en matière plastique moulée par injection.

4. Procédé selon la revendication 3, dans lequel l'une desdites moitiés comprend des canaux de passage

(551, 561) dans celles-ci, lesdits canaux de passage en communication avec lesdites entrées (350, 360).

5. Procédé selon la revendication 4, comprenant en outre l'étape d'application d'un joint réentrant (790, 2310, 2520, 2530, 2640) à des canaux de passage dans ledit boîtier.

6. Procédé selon la revendication 1, dans lequel ledit substrat (100) comprend des repères d'alignement (145) pour former lesdits groupements de sondes (110) sur celui-ci dans une position désirée, et dans lequel lesdits repères d'alignement (145) sont utilisés pour identifier des endroits pour ladite séparation dudit substrat en puces (120).

7. Procédé selon la revendication 1, dans lequel ledit substrat comprend des repères d'alignement pour former lesdits groupements de sondes sur celui-ci dans une position désirée, et dans lequel ladite étape d'appariement desdites puces audit boîtier utilise lesdits repères d'alignement pour positionner lesdites puces dans une position désirée sur ledit boîtier.

8. Procédé selon la revendication 1, dans lequel ledit boîtier comprend une structure d'alignement sur celui-ci, dans lequel ladite étape d'appariement de ladite puce audit boîtier utilise lesdites structures d'alignement pour positionner ledit boîtier à une position désirée.

9. Procédé selon la revendication 1, dans lequel ledit boîtier comprend une structure d'alignement sur celui-ci, et comprenant en outre l'étape d'identification de l'endroit d'au moins une cible sur ledit groupement de sondes dans un analyseur, dans lequel ledit boîtier est placé dans une position désirée dans ledit analyseur en utilisant ladite structure d'alignement.

10. Procédé selon la revendication 9, dans lequel ladite structure d'alignement est une pluralité de trous dans ledit boîtier.

11. Procédé selon la revendication 1, dans lequel ladite étape de formation d'une pluralité de groupements de sondes comprend les étapes de :

exposition sélective dudit substrat à la lumière ;  
couplage de monomères sélectionnés audit substrat lorsque ledit substrat a été exposé à la lumière ;

12. Procédé selon la revendication 1, dans lequel ladite étape de séparation comprend les étapes de :

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- tracage dudit substrat en des endroits désirés ;  
rupture dudit substrat le long desdites lignes de tracage.
13. Procédé selon la revendication 1, dans lequel ladite étape de formation d'une pluralité de groupements de sondes sur ledit substrat est une étape de formation d'une pluralité de groupements de sondes oligonucléotides sur ledit substrat. 5
14. Procédé selon la revendication 13, comprenant en outre les étapes de passage de molécules cibles d'oligonucléotides marquées à travers ladite chambre de réaction et d'identification si lesdites molécules cibles ont adhéré audit substrat. 10
15. Procédé selon la revendication 14, dans lequel ledit boîtier comprend une sonde de température et comprenant en outre l'étape de surveillance et d'ajustement d'une température dans ladite chambre de réaction. 15
16. Procédé selon la revendication 1, dans lequel ledit boîtier est formé par les étapes de : 20
- formation des première et seconde parties du boîtier ; et  
soudage acoustique desdites première et seconde parties du boîtier ensemble. 25
17. Procédé selon la revendication 1, dans lequel ladite étape d'appariement desdites puces à des boîtiers comprend l'étape de liaison desdites puces audit boîtier avec un adhésif. 30
18. Procédé selon la revendication 17, dans lequel lesdits boîtiers comprennent une région évidée (550) sur ceux-ci, afin que lesdites puces (120) ne s'étendent pas au-dessus d'une surface desdits boîtiers. 35
19. Procédé selon la revendication 1, comprenant en outre l'étape de passage de molécules cibles à travers ladite chambre de réaction. 40
20. Procédé selon la revendication 19, dans lequel ladite étape de passage est une étape de passage de matière depuis une entrée le long d'une première diagonale d'une chambre de réaction généralement rectangulaire à une sortie le long de ladite diagonale de ladite chambre de réaction généralement rectangulaire. 45
21. Procédé selon la revendication 19, dans lequel ladite étape de passage de molécules cibles à travers ladite chambre de réaction comprend les étapes de perçage d'un septum d'entrée et de passage desdites molécules cibles dans un fluide à travers ladite chambre de réaction. 50
22. Appareil pour encapsuler un substrat, ledit appareil comprenant: 55
- un substrat ayant une première surface (110) et une seconde surface (120), ladite première surface comprenant un groupement de sondes ;  
un corps ayant une surface de montage avec une cavité de fluide,  
ladite seconde surface fixée à ladite cavité ; et  
un couvercle fixé à ladite surface de montage pour fermer hermétiquement ladite cavité ;
- dans lequel ladite cavité comprend un orifice d'entrée et un orifice de sortie, lesdits orifices d'entrée et de sortie permettant aux fluides de circuler dans et à travers ladite cavité.
23. Appareil selon la revendication 22, dans lequel lesdits orifices d'entrée et de sortie comprennent un joint rentrable.
24. Appareil selon la revendication 22, dans lequel ledit groupement de sondes comprend un groupement de sondes oligonucléotides.
25. Appareil selon la revendication 22, dans lequel ledit corps comprend un creux pour recevoir un régulateur de température pour réguler et maintenir la température de réaction dans ladite cavité.
26. Appareil selon la revendication 22, dans lequel ledit corps comprend une première moitié appariée à une seconde moitié.
27. Appareil selon la revendication 26, dans lequel lesdites première et seconde moitiés sont en matière plastique moulée par injection.
28. Appareil selon la revendication 27, dans lequel une desdites moitiés comprend une cavité, ladite cavité ayant un orifice d'entrée et un orifice de sortie.
29. Appareil selon la revendication 28, dans lequel une desdites moitiés comprend des canaux de passage, lesdits canaux de passage en communication avec lesdits orifices d'entrée et de sortie lorsque lesdites première et seconde moitiés sont assemblées ensemble.
30. Appareil selon la revendication 29, dans lequel lesdits canaux de passage comprennent un joint rentrant pour fermer hermétiquement le fluide dans ladite cavité.
31. Appareil selon la revendication 22, dans lequel ledit corps comprend en outre une structure d'alignement, ladite structure d'alignement utilisée pour

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- maintenir ledit corps dans une position désirée lorsqu'il est monté sur un système de détection.
32. Appareil selon la revendication 31, dans lequel ladite structure d'alignement comprend une pluralité de trous. 5
33. Appareil selon la revendication 31, dans lequel ladite structure d'alignement comprend un bord non affleurant. 10
34. Appareil selon la revendication 22, dans lequel le substrat est un film de Langmuir Blodgett polymérisé, du verre fonctionnalisé, du Si, du Ge GaAs, du GaP, du SiO<sub>2</sub>, du SiN<sub>4</sub>, du silicium modifié, du (poly) tétrafluoroéthylène, du difluorure de (poly)vinylidène, du polystyrène, du polycarbonate ou des combinaisons de ceux-ci. 15
35. Appareil selon la revendication 22, dans lequel le substrat est le couvercle fermant hermétiquement la cavité. 20
36. Appareil selon la revendication 22, dans lequel l'appareil est conçu asymétriquement pour assurer une orientation correcte du boîtier lorsqu'il est inséré dans un support. 25
37. Appareil selon la revendication 22, dans lequel la cavité est légèrement plus petite que la région de surface de la puce à placer sur celle-ci et a un volume suffisant pour réaliser l'hybridation. 30
38. Procédé d'évaluation de puces à sondes comprenant les étapes de : 35
- formation d'une pluralité de groupements de sondes sur un substrat ;
  - séparation dudit substrat en une pluralité de puces, chacune desdites puces comprenant au moins un groupement de sondes sur celles-ci ;
  - appariement d'au moins une desdites puces à un boîtier, ledit boîtier comprenant une chambre de réaction, ladite chambre de réaction en communication de fluide avec une entrée et une sortie, ledit au moins un groupement de sondes en communication de fluide avec ladite chambre de réaction ; et
  - passage de molécules cibles marquées dans ladite chambre de réaction, lesdites molécules cibles marquées réagissant avec ledit au moins un groupement de sondes. 40 45 50
39. Procédé selon la revendication 38, dans lequel ladite étape de formation d'une pluralité de groupements de sondes est une étape de formation d'une pluralité de groupements de sondes oligonucléotides. 55
40. Procédé selon la revendication 38, dans lequel ladite entrée et ladite sortie comprennent des joints réentrant, et dans lequel ladite étape de passage de molécules cibles marquées dans ladite chambre de réaction comprend les étapes de : 5
- perçage dudit joint de ladite entrée ;
  - perçage dudit joint de ladite sortie ; et
  - passage desdites molécules cibles marquées depuis ladite entrée dans ladite cavité et hors de celle-ci à travers ladite sortie.
41. Procédé selon la revendication 38, comprenant en outre l'étape d'agitation desdites molécules cibles pour faciliter la réaction entre ledit au moins un groupement de sondes et lesdites molécules cibles marquées.
42. Procédé selon la revendication 41, comprenant en outre l'étape d'identification d'au moins un emplacement où lesdites molécules cibles marquées sont placées sur ledit au moins un groupement de sondes.
43. Procédé selon la revendication 42, où ladite étape d'identification comprend l'étape de placement dudit boîtier dans un analyseur, ledit analyseur étant capable d'imager lesdites molécules cibles marquées sur ledit au moins un groupement de sondes. 25
44. Procédé selon la revendication 43, dans lequel ledit boîtier comprend une structure d'alignement de telle sorte que ledit boîtier soit placé dans une position désirée dans ledit analyseur. 30
45. Procédé selon la revendication 44, dans lequel ladite structure d'alignement comprend un bord non affleurant. 35
46. Procédé selon la revendication 44, dans lequel ladite structure d'alignement comprend une pluralité de trous d'alignement. 40

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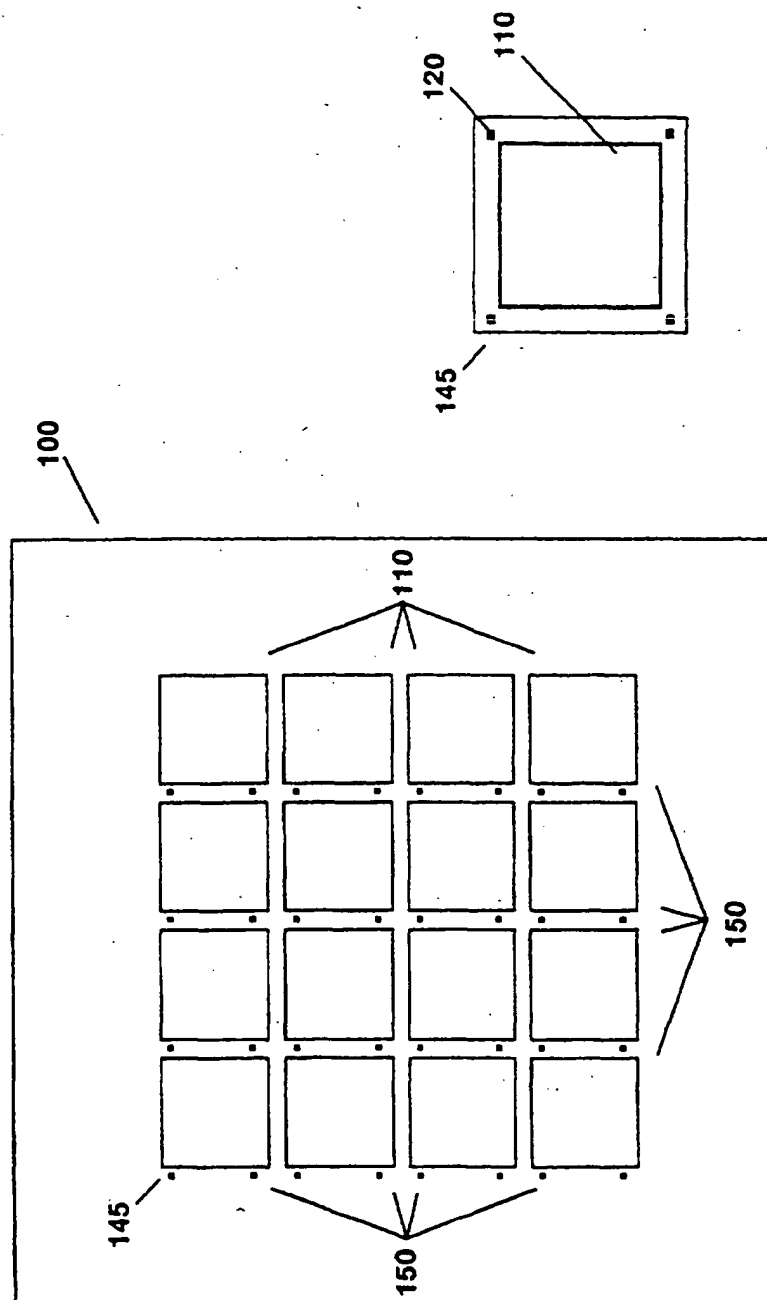


Figure 1b

Figure 1a

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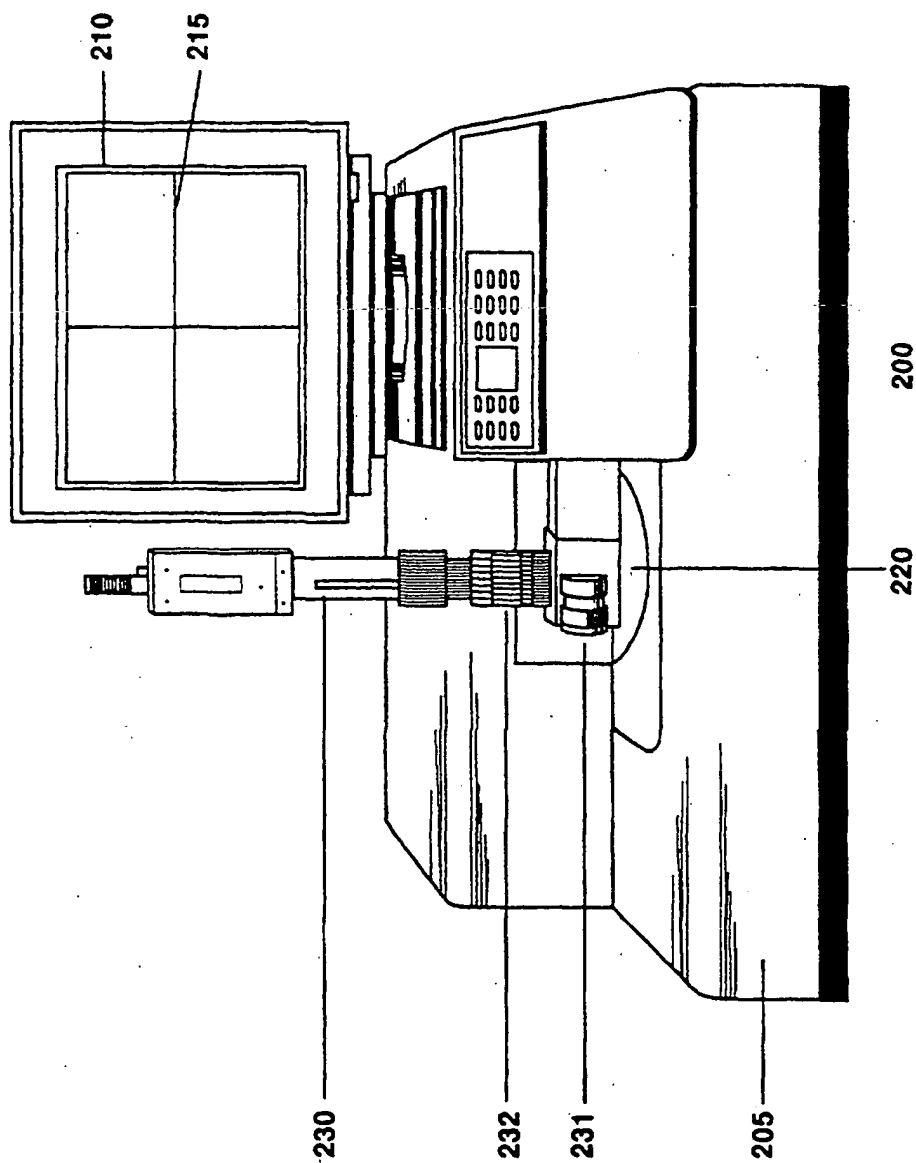


Figure 2a

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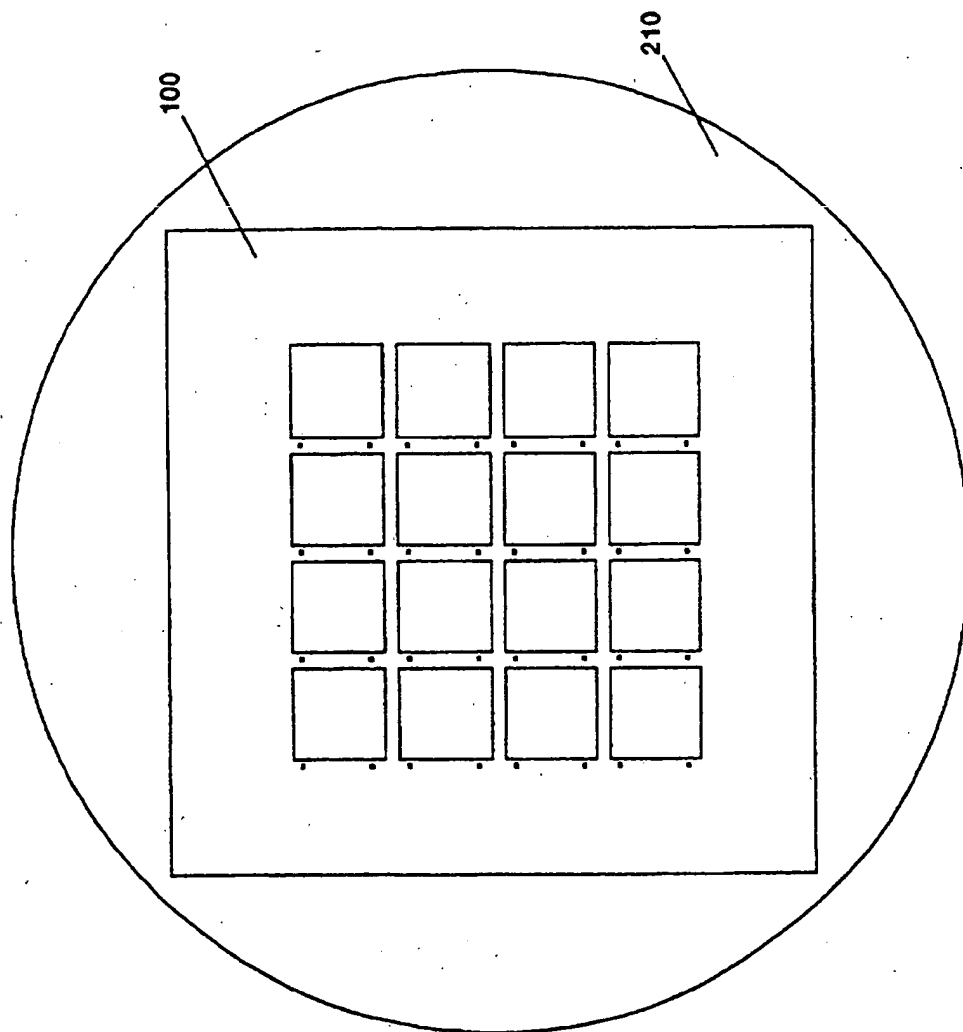


Figure 2b

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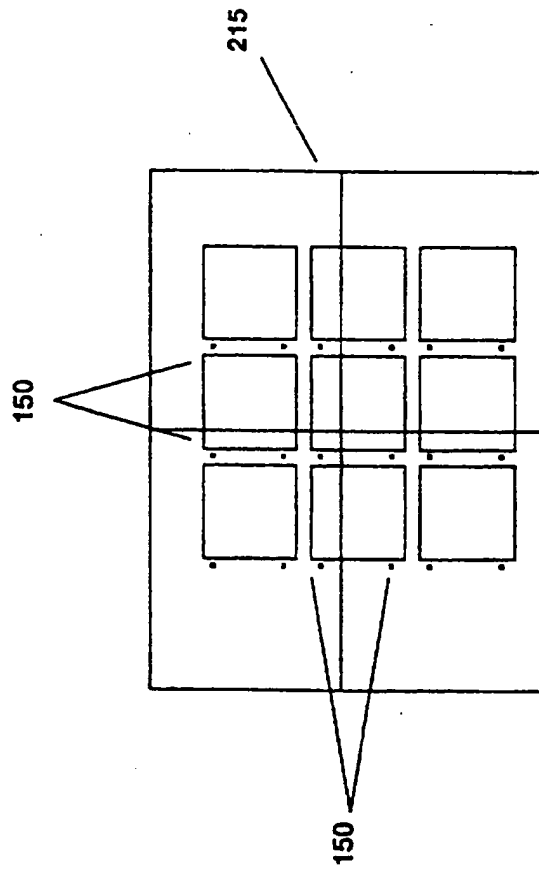


Figure 2c

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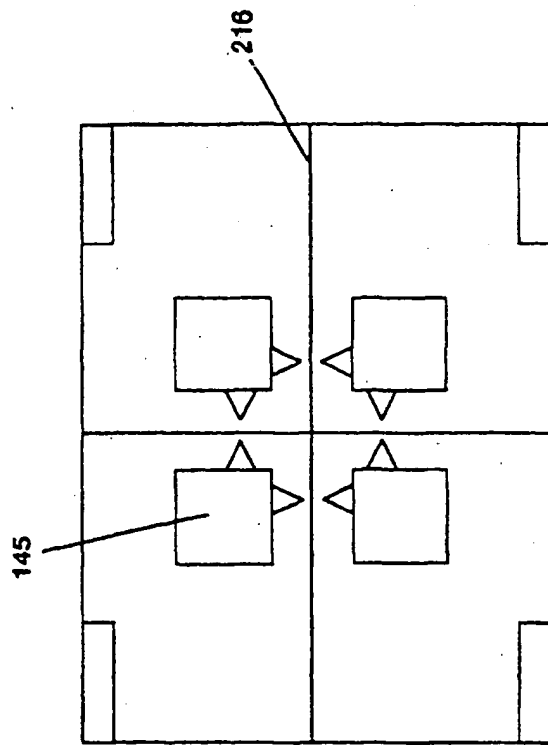


Figure 2d



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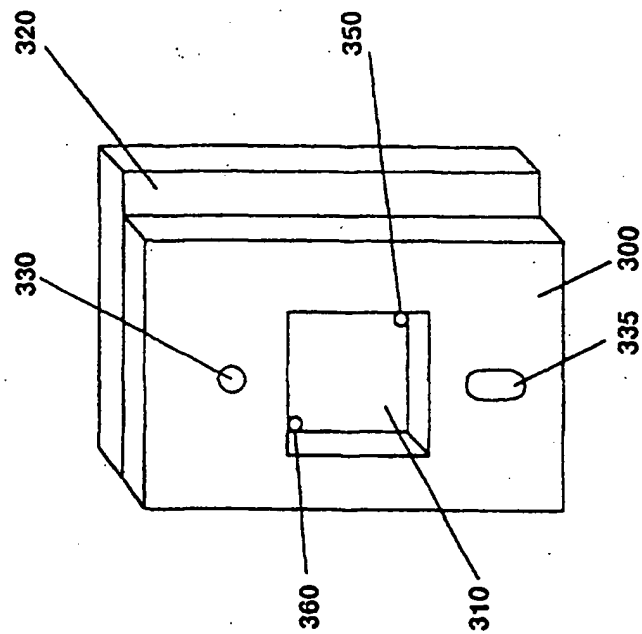


Figure 3

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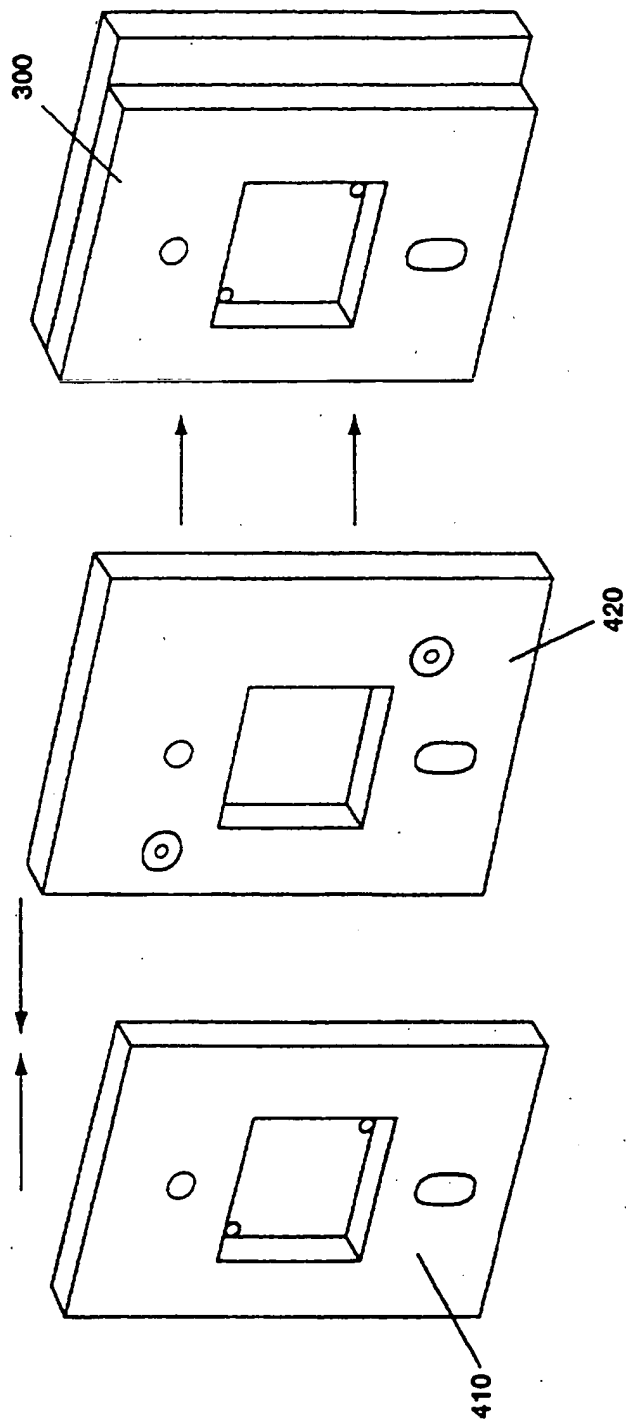


Figure 4

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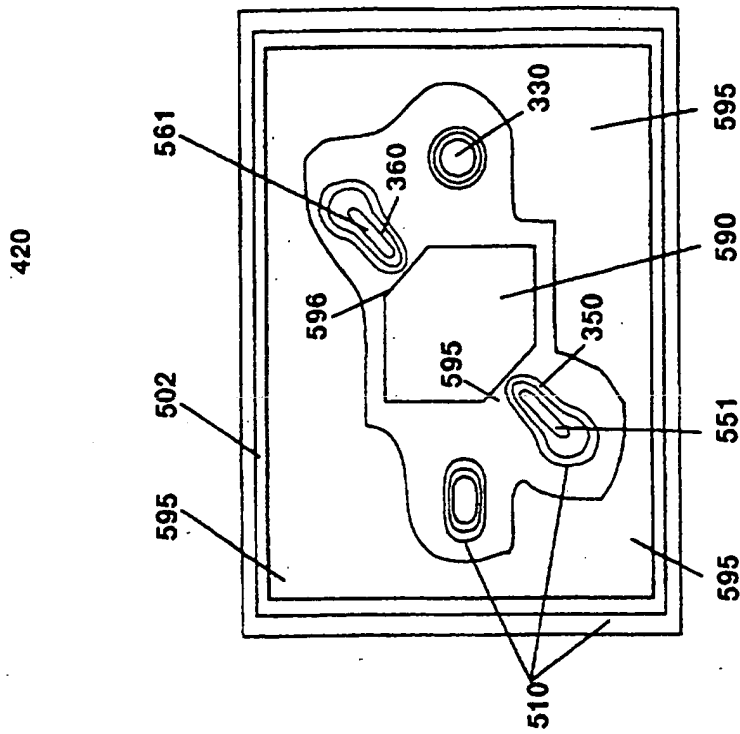


Figure 5a

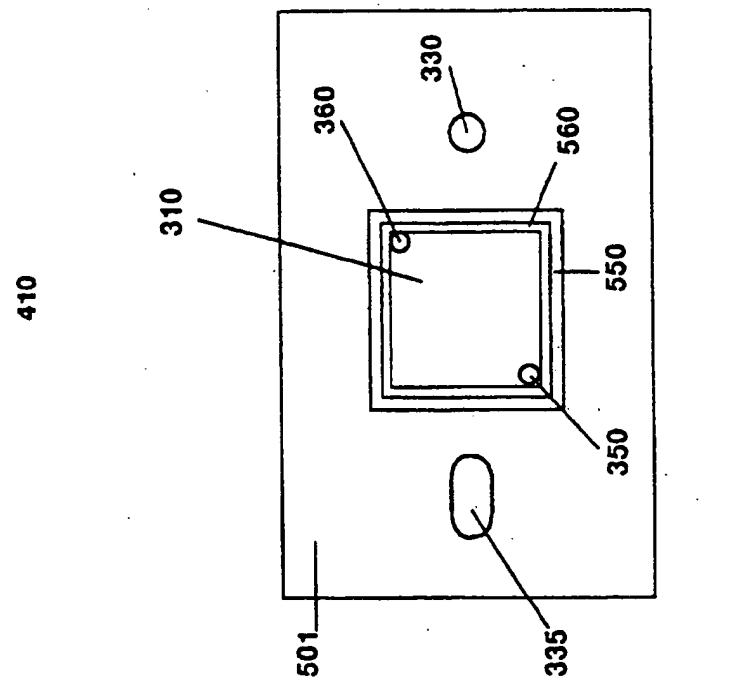


Figure 5b

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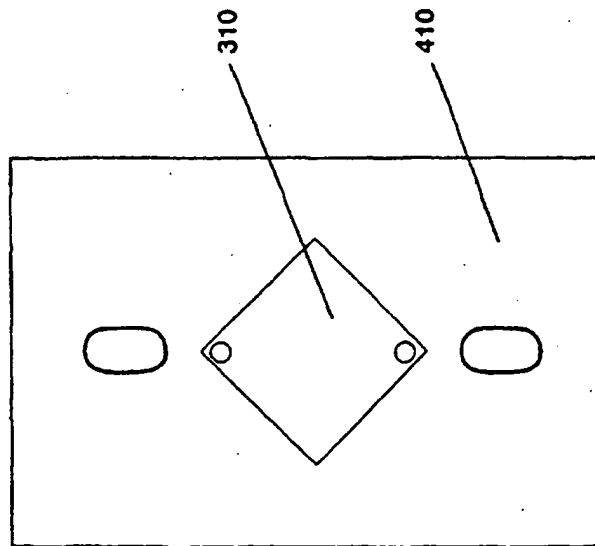


Figure 5c

EP 0 695 941 B1

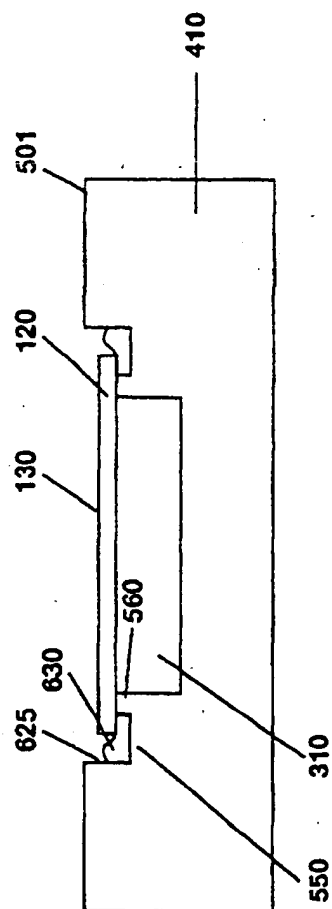


Figure 6

EP 0 695 941 B1

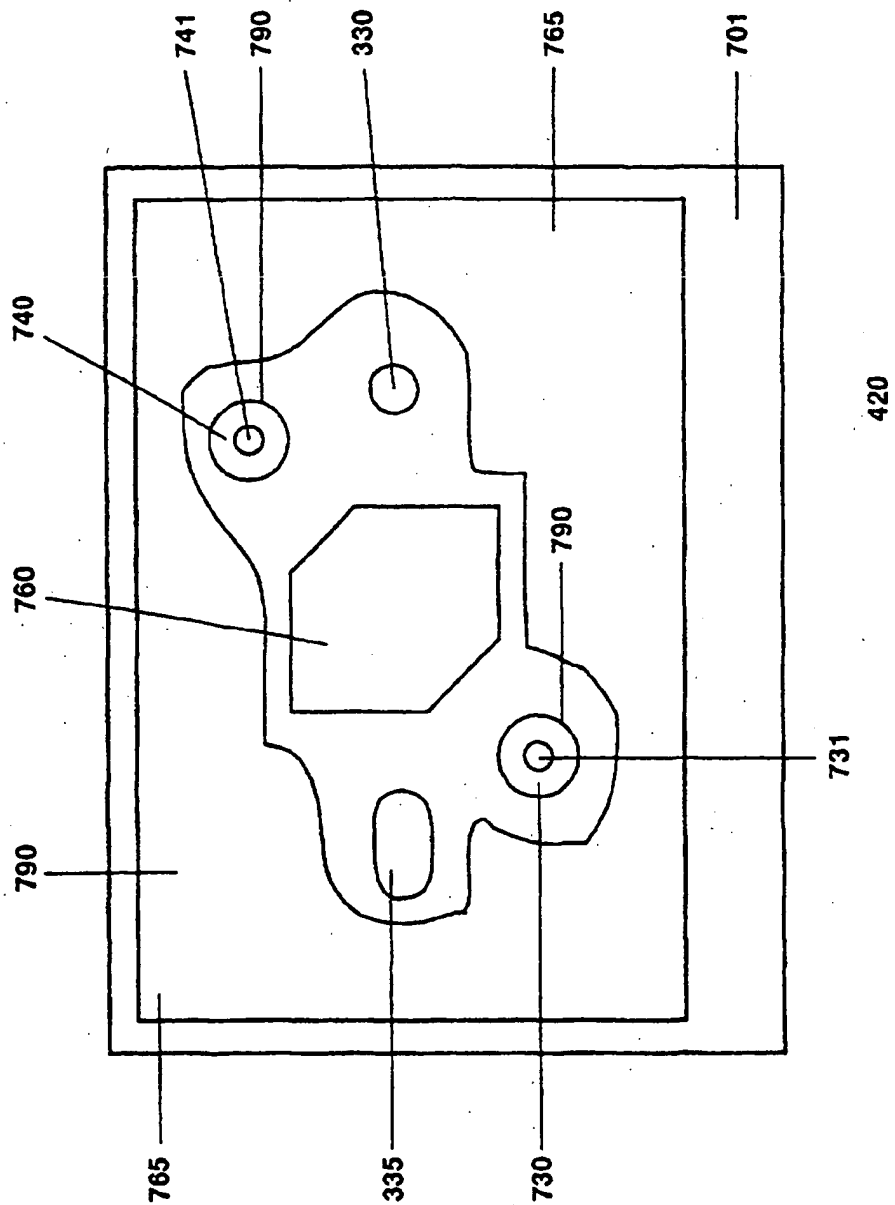


Figure 7

EP 0 695 941 B1

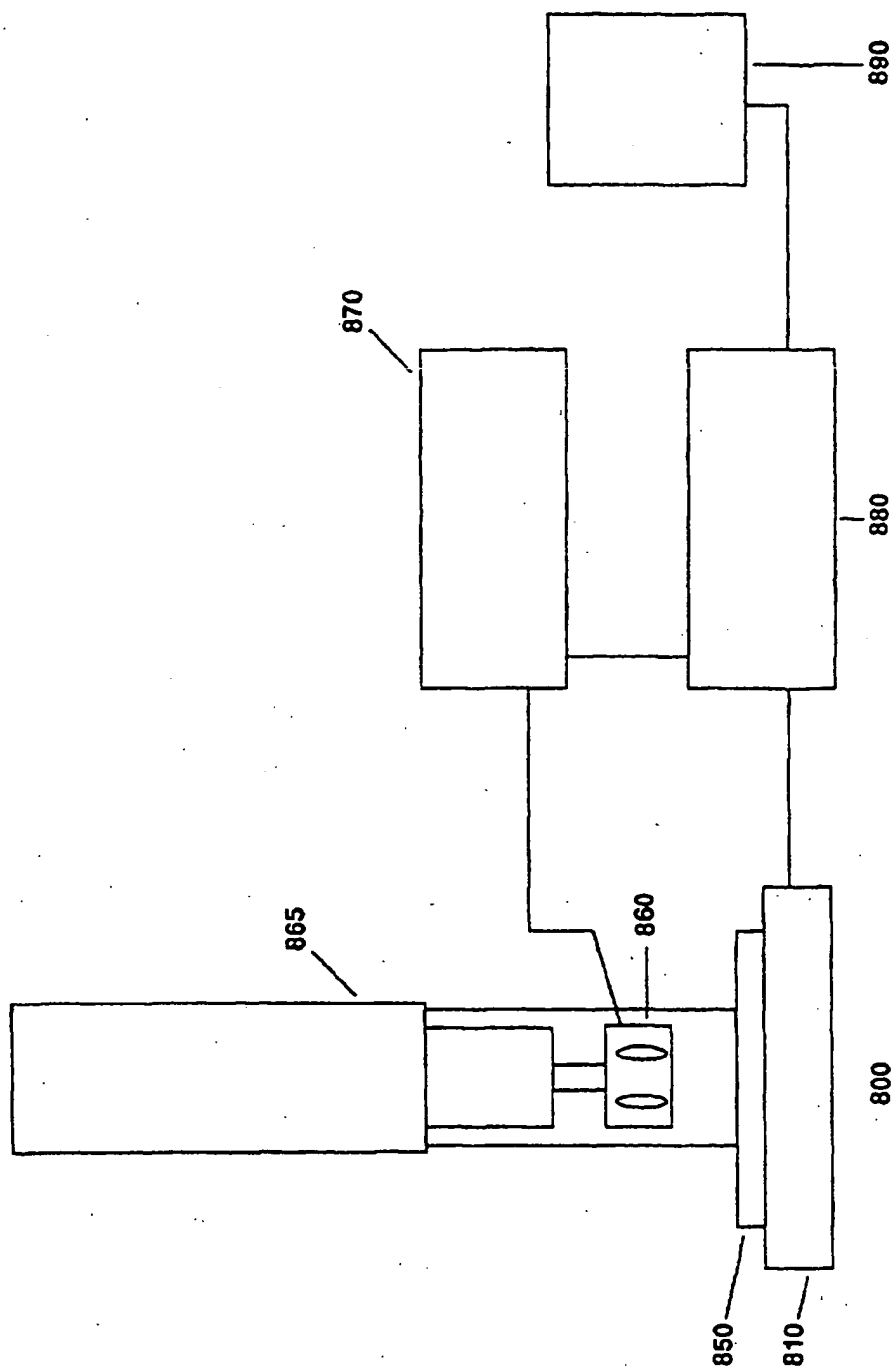


Figure 8a

EP 0 695 941 B1

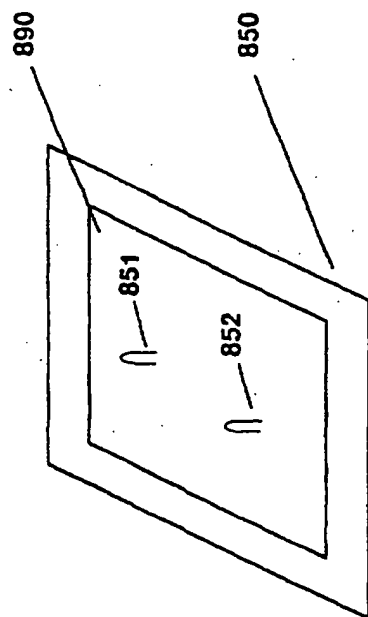


Figure 8b



EP 0 695 941 B1

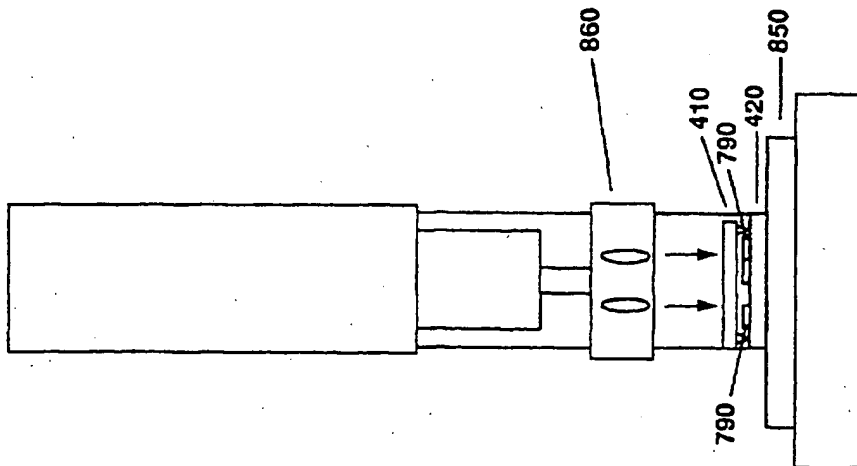


Figure 9a

EP 0 695 941 B1

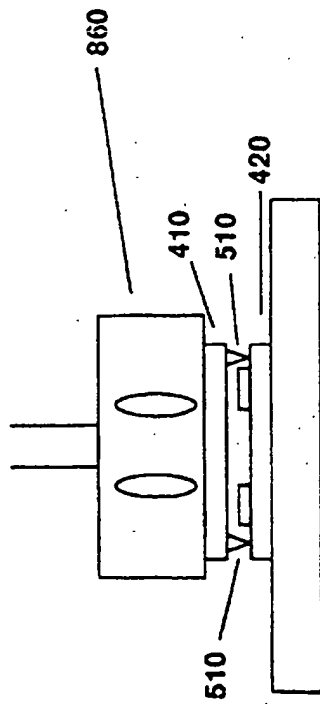


Figure 9b

EP 0 695 941 B1

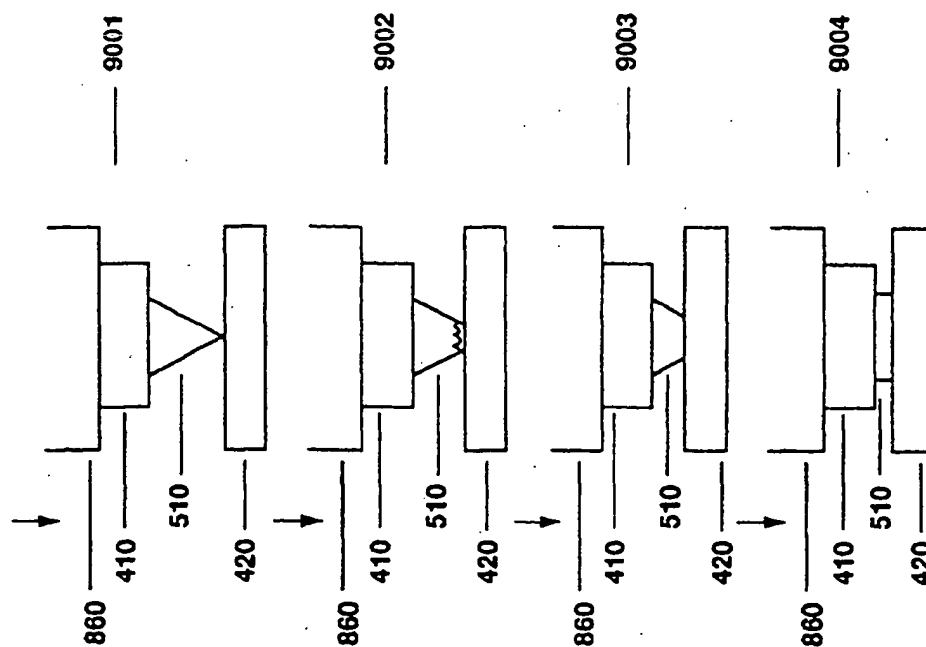


Figure 9c

EP 0 695 941 B1

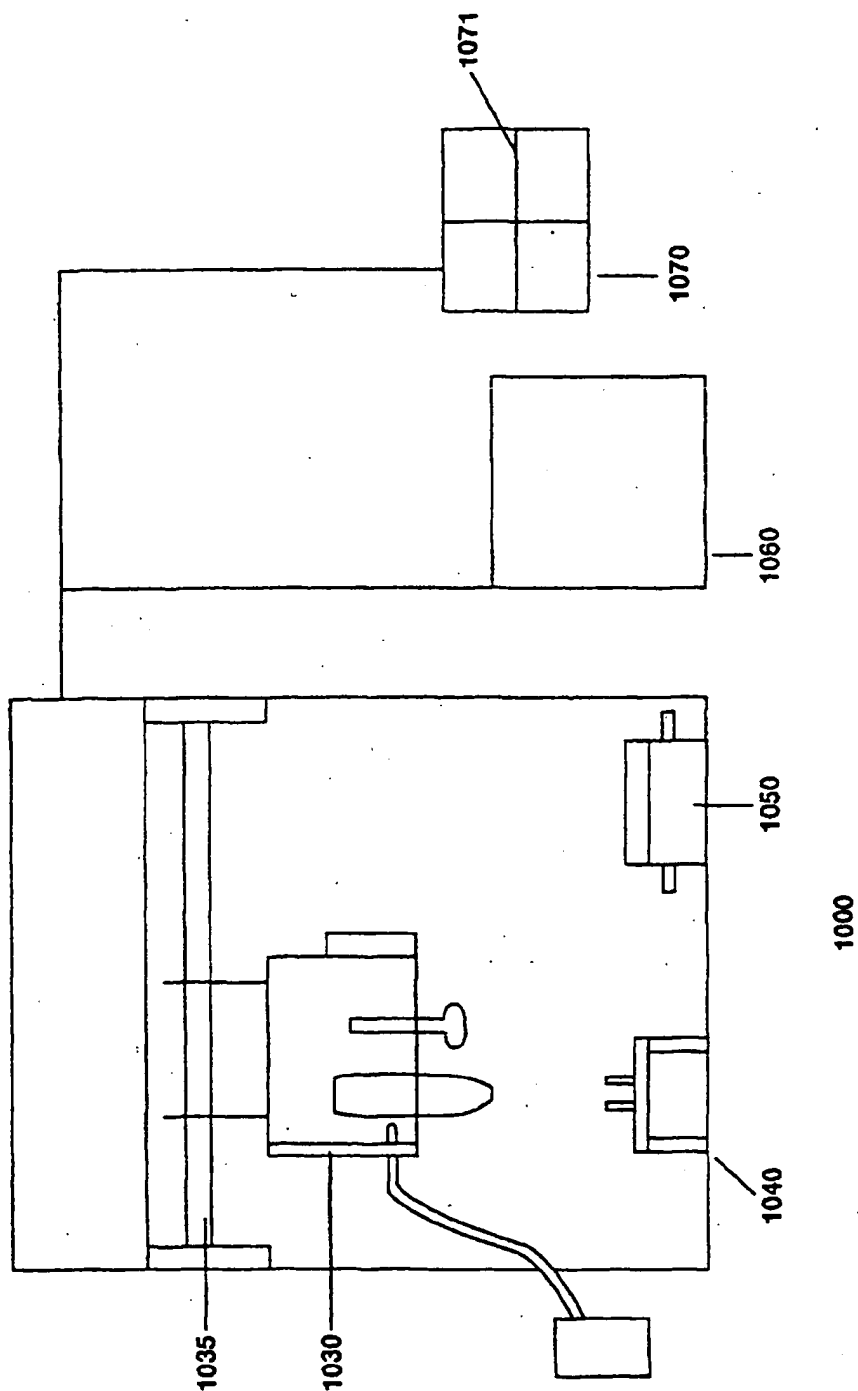


Figure 10

EP 0 695 941 B1

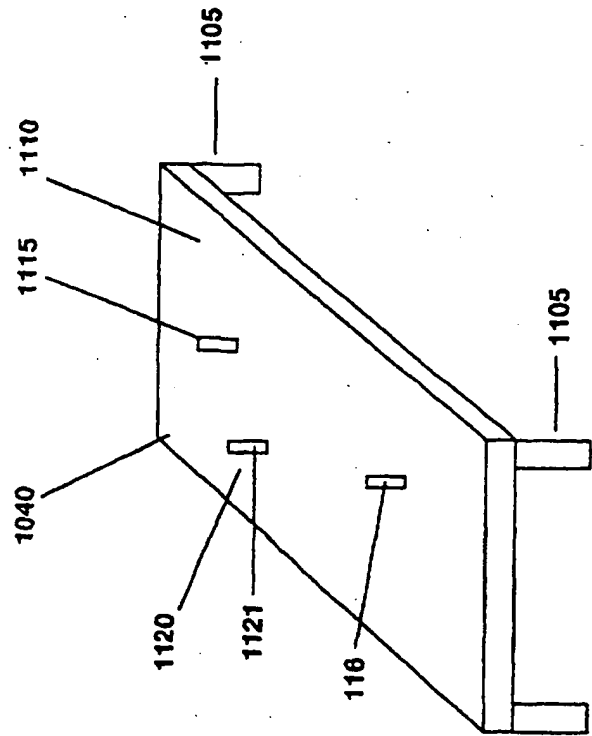


Figure 11

EP 0 695 941 B1

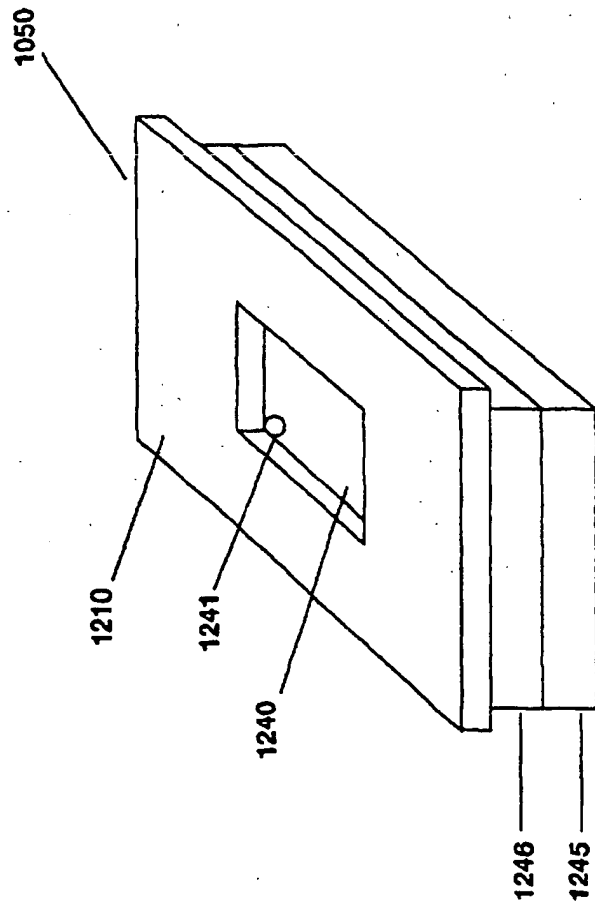


Figure 12a

EP 0 695 941 B1

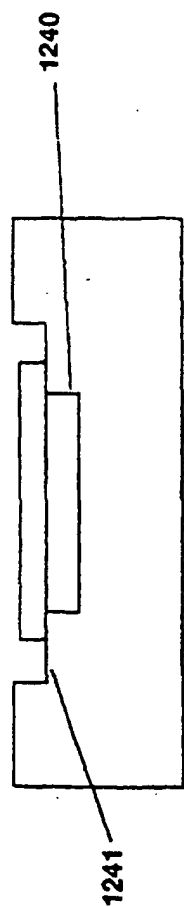


Figure 12b

EP 0 695 941 B1

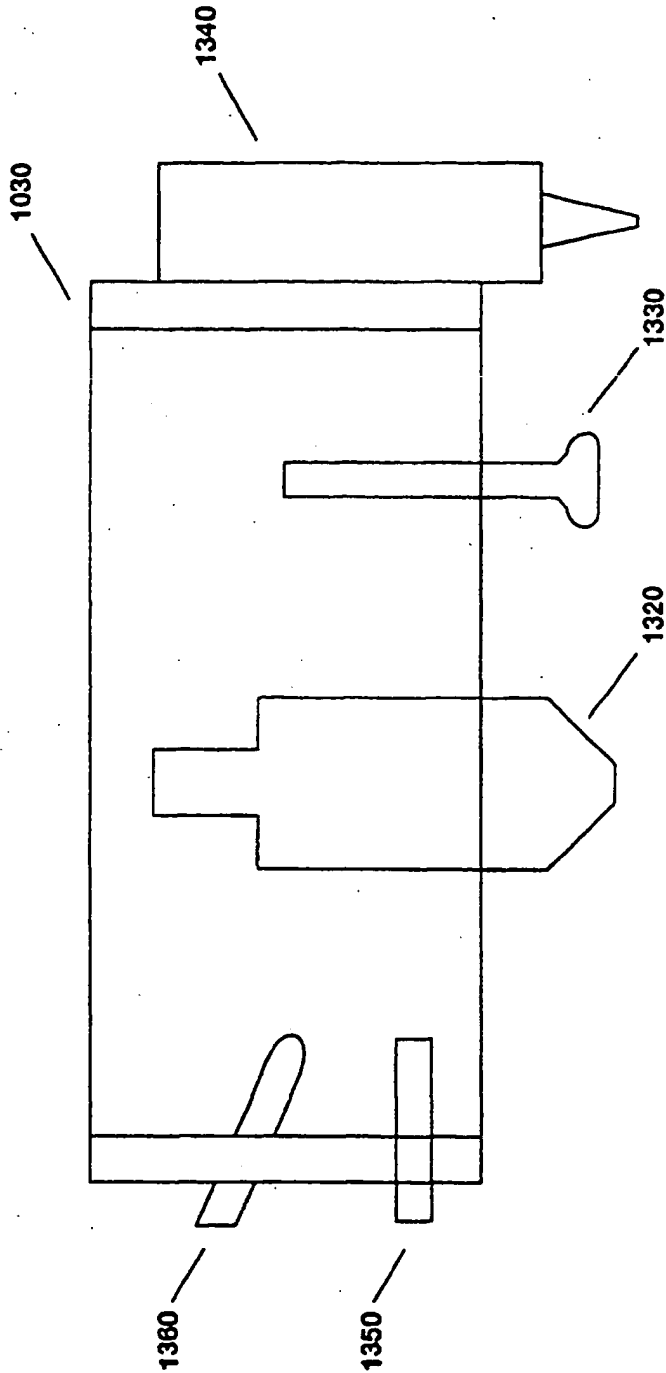


Figure 13



EP 0 695 941 B1

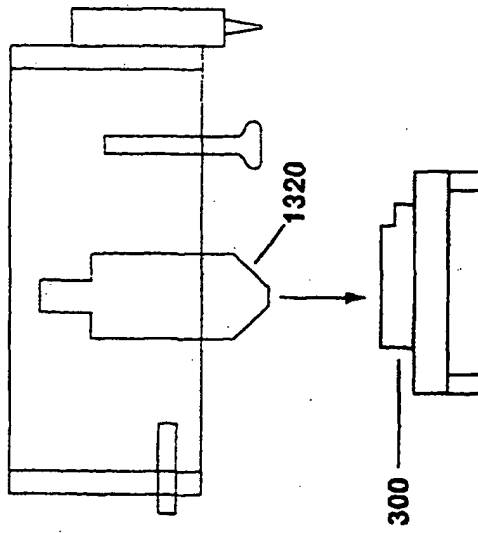


Figure 14a

EP 0 695 941 B1

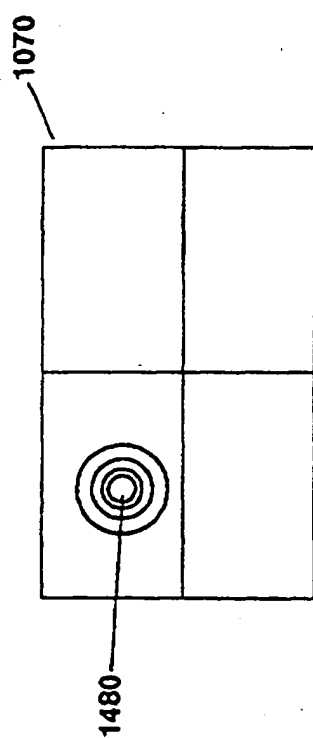


Figure 14b

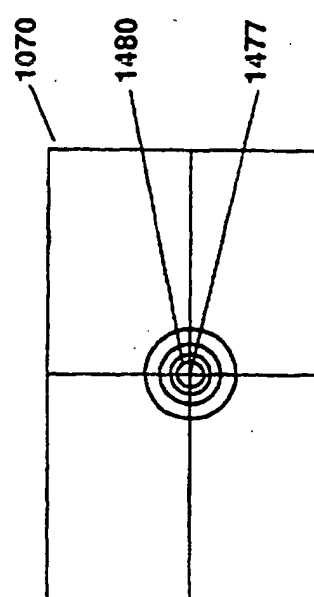


Figure 14c

EP 0 695 941 B1

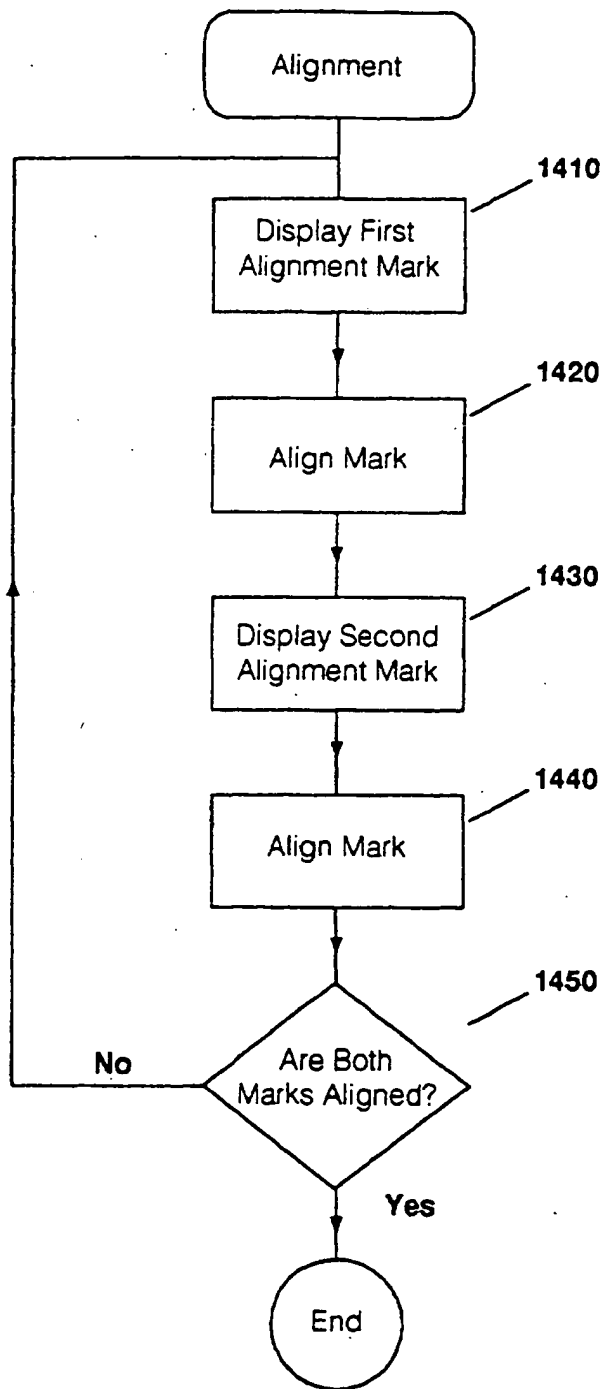


Figure 14d

EP 0 695 941 B1

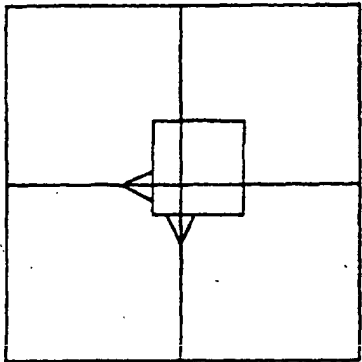


Figure 15e

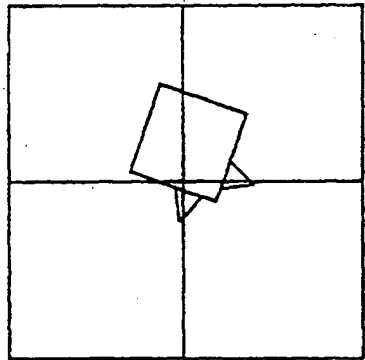


Figure 15b

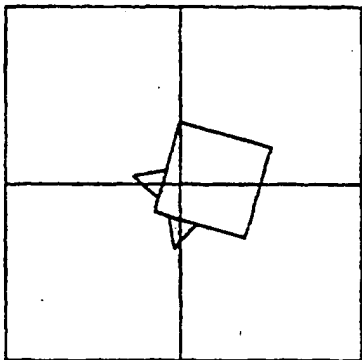


Figure 15d

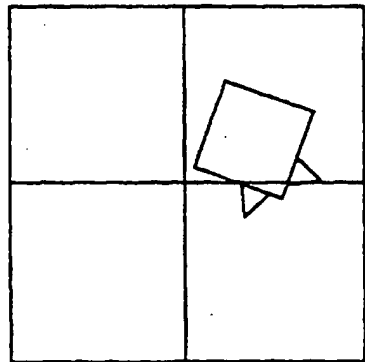


Figure 15a

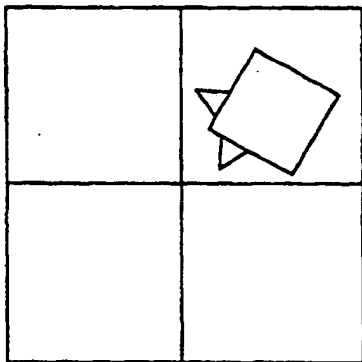


Figure 15c

EP 0 695 941 B1

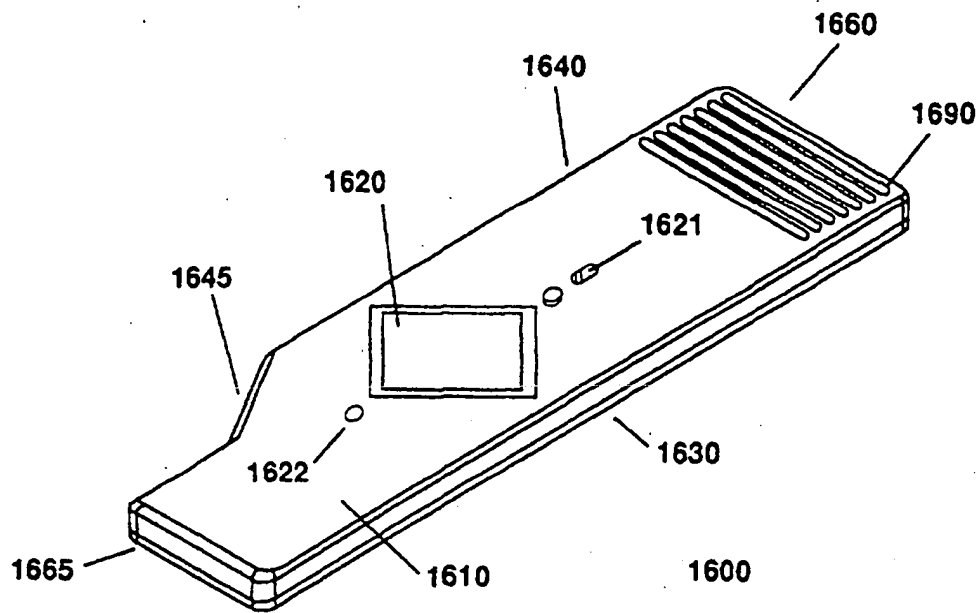


Figure 16a

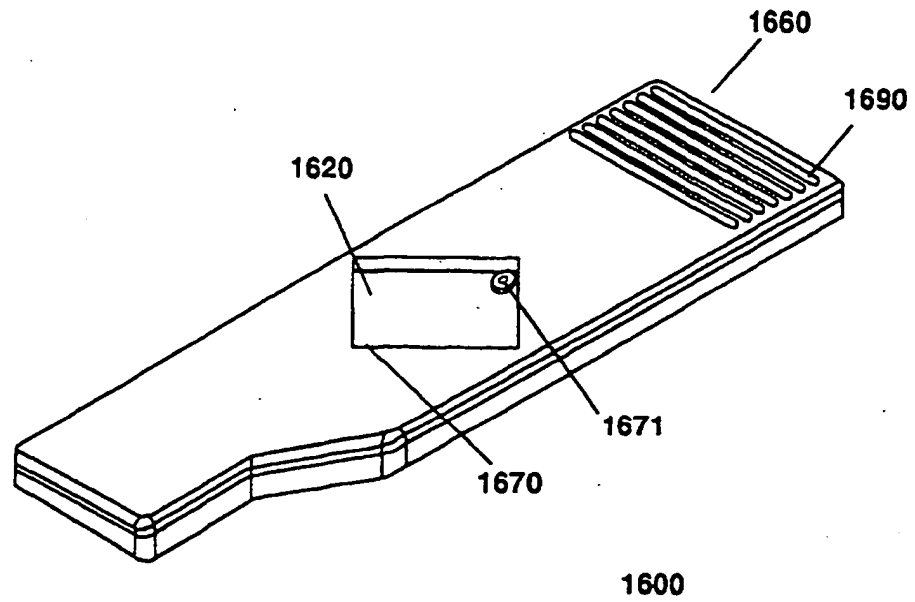


Figure 16b

EP 0 695 941 B1

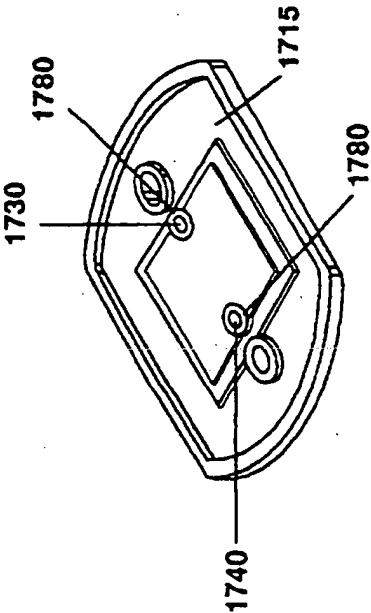


Figure 17b

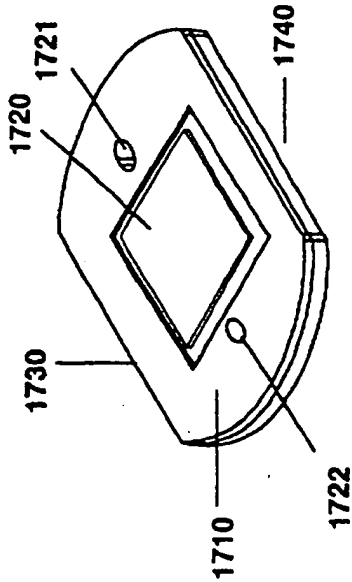


Figure 17a

1700

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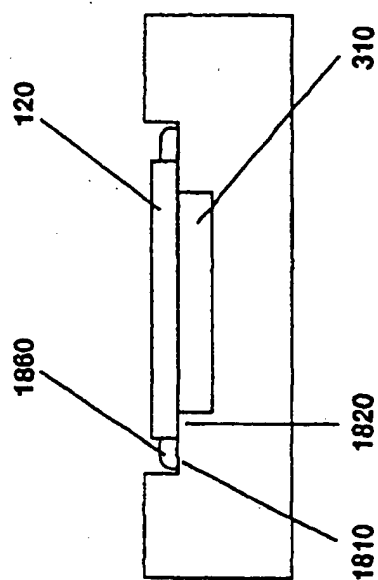


Figure 18

EP 0 695 941 B1

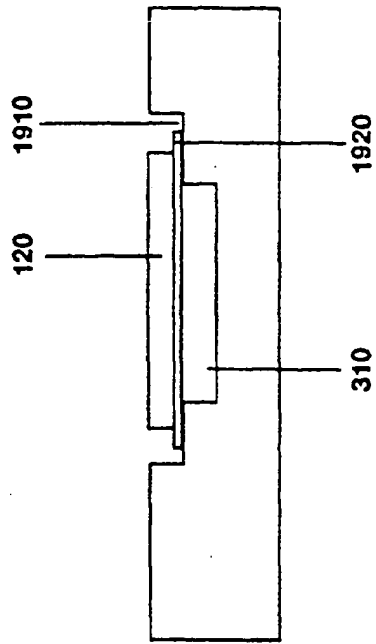


Figure19



EP 0 695 941 B1

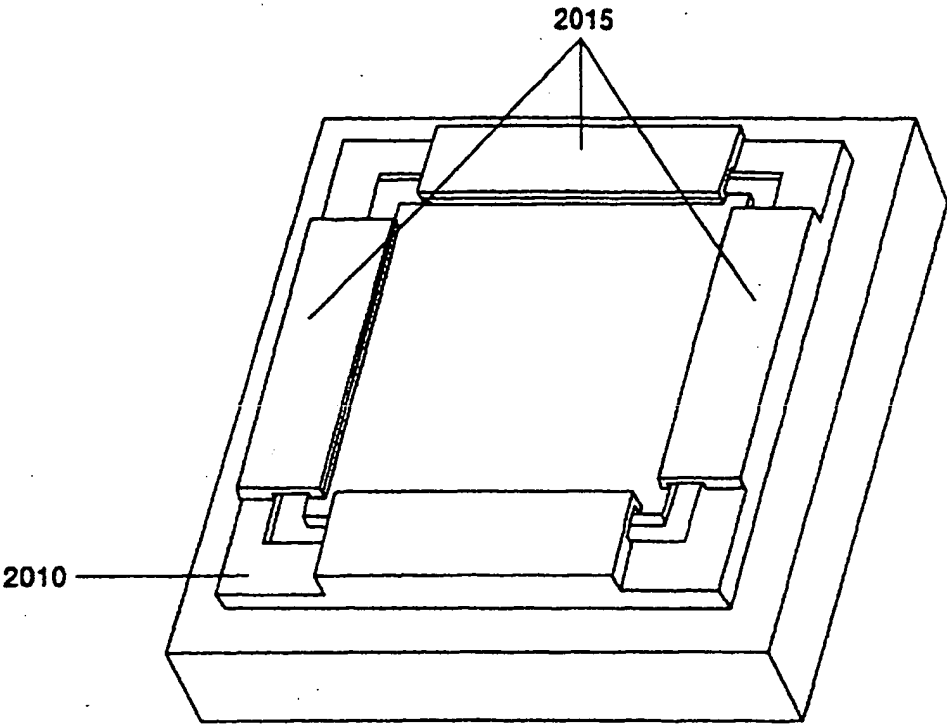


Figure 20a

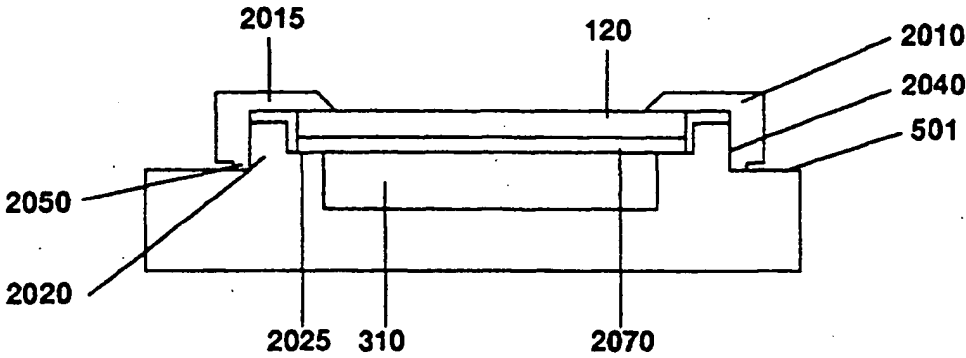


Figure 20b

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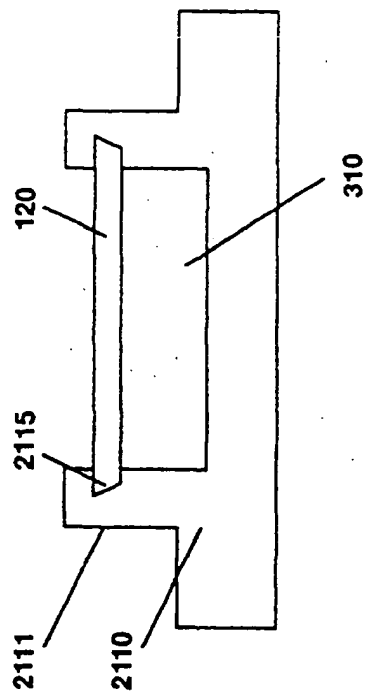


Figure 21

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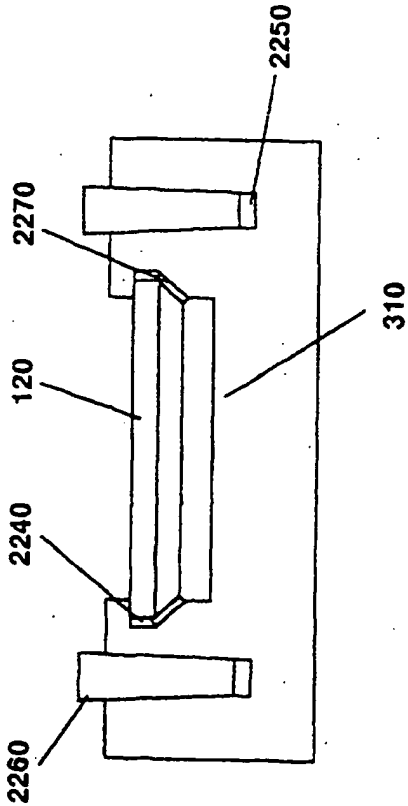


Figure 22

EP 0 695 941 B1

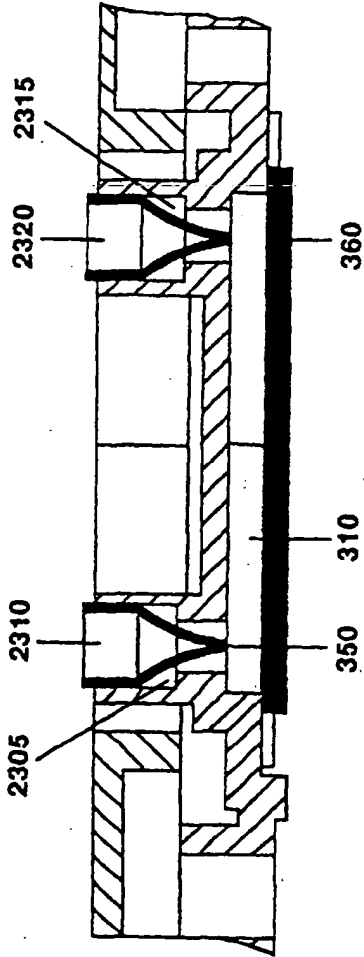


Figure 23

EP 0 695 941 B1

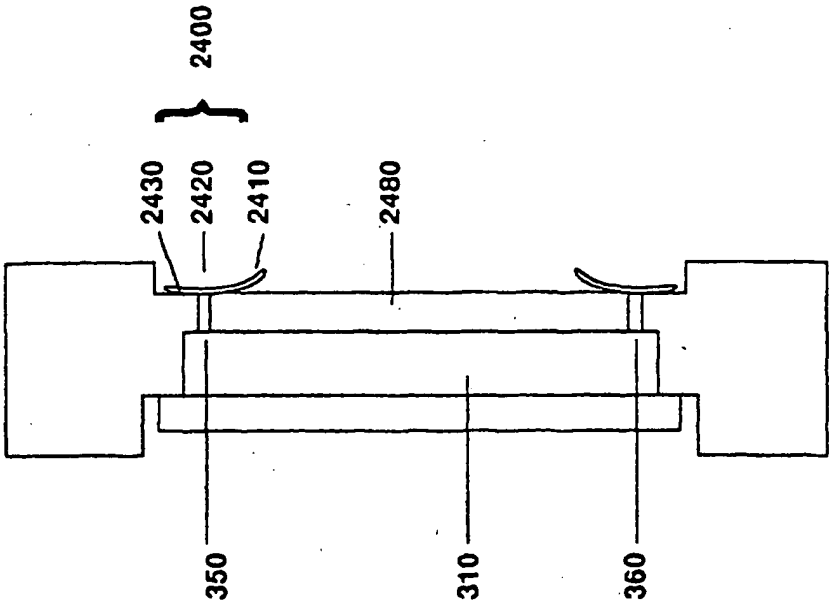


Figure 24

EP 0 695 941 B1

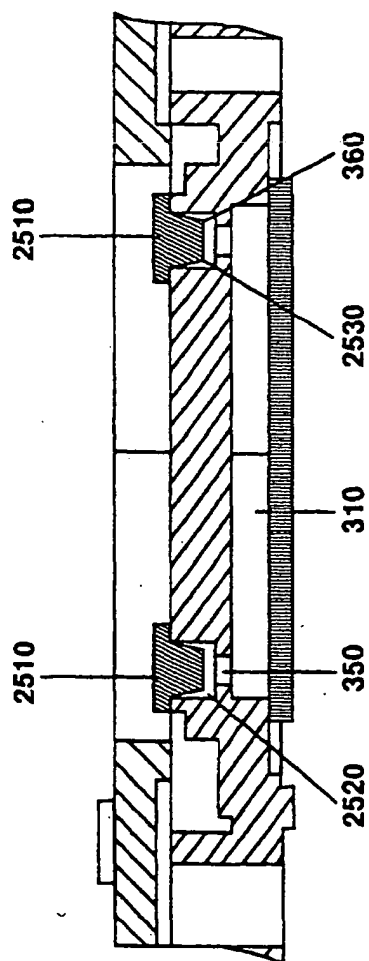


Figure 25

EP 0 695 941 B1

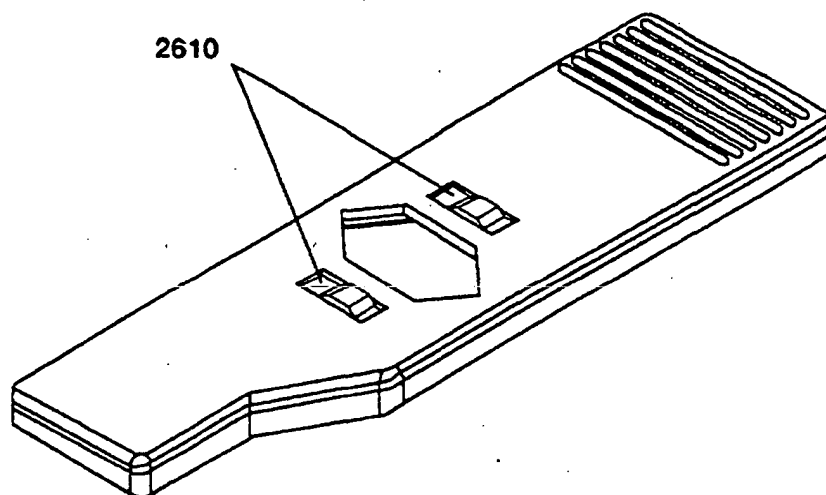
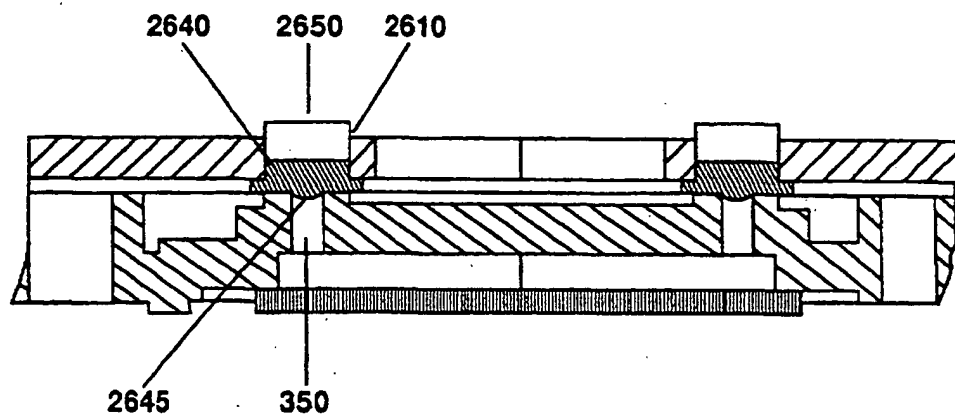


Figure 26a



EP 0 695 941 B1

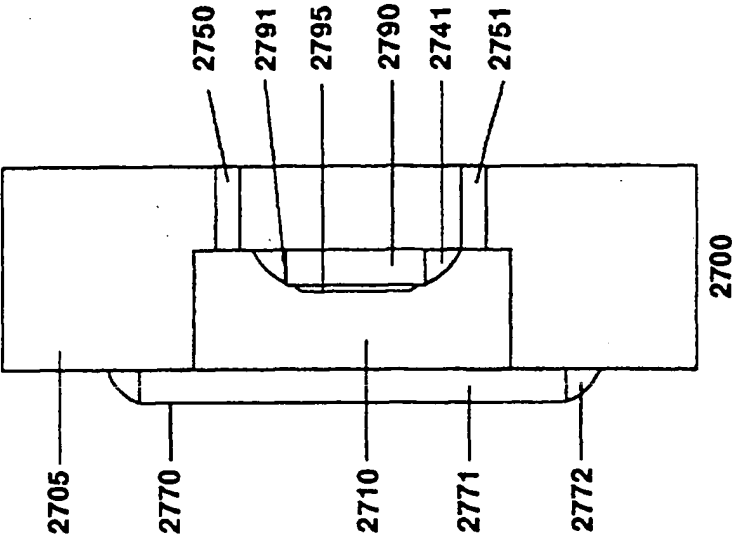


Figure 27b

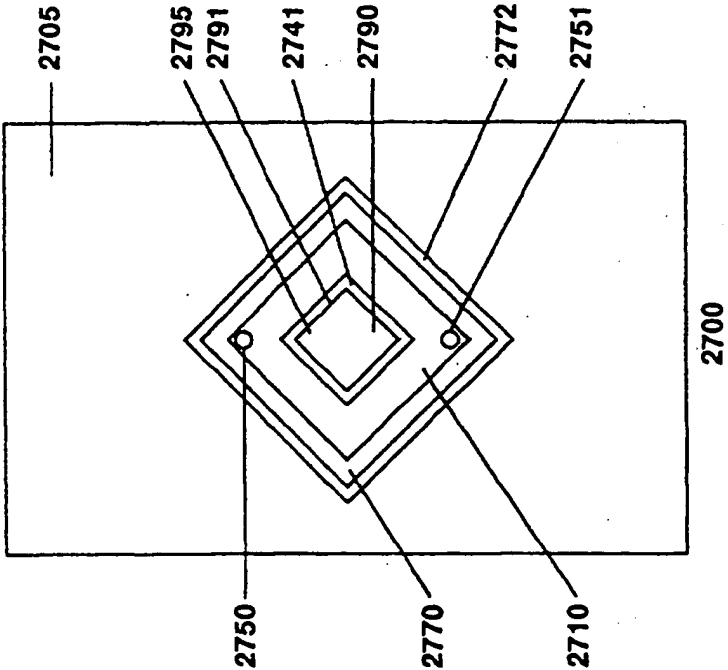


Figure 27a



EP 0 695 941 B1

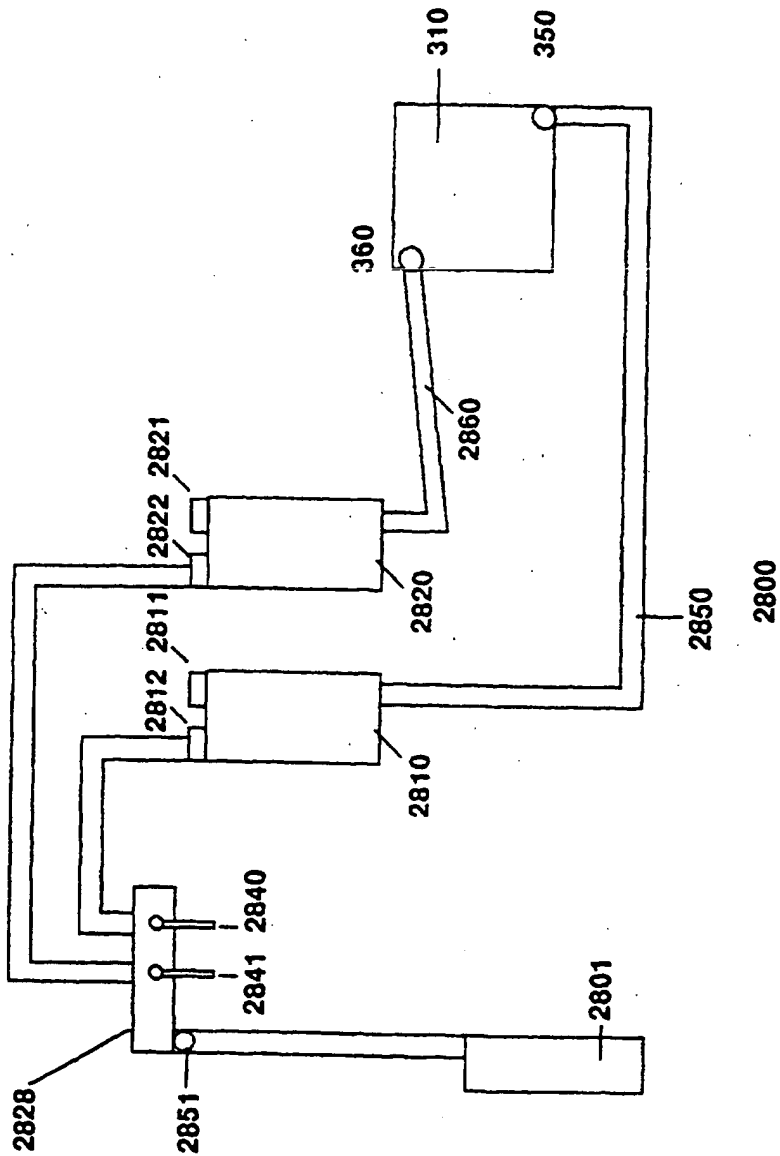


Figure 28

EP 0 695 941 B1

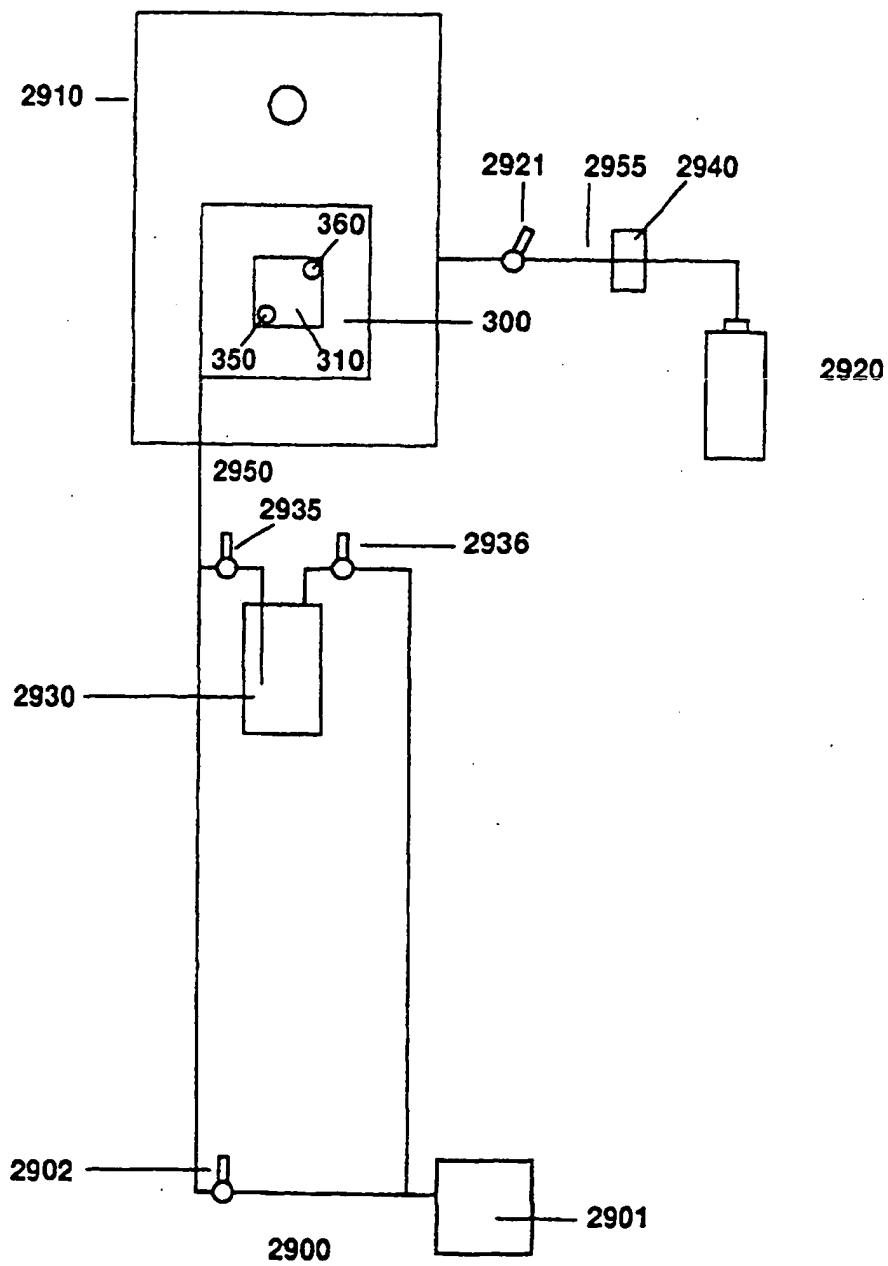


Figure 29

EP 0 695 941 B1

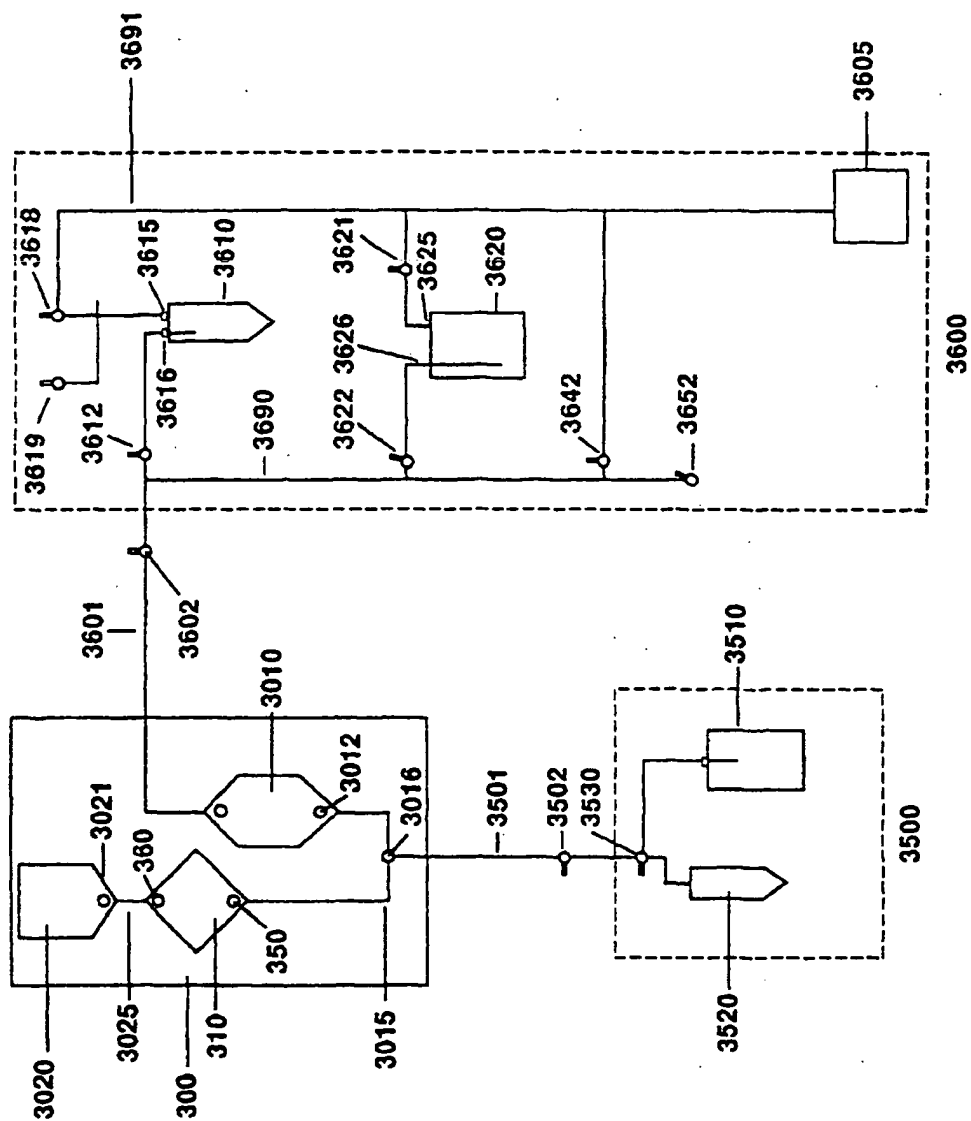


Figure 30